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Display device, display module, and electronic device

Abstract

A novel display device or the like in which a transistor connected to a scan line has small gate capacitance is provided. A novel display device or the like in which a scan line has low resistance is provided. A novel display device or the like in which pixels can be arranged with high density is provided. A novel display device or the like that can be manufactured without an increase in cost is provided. In a transistor including a first gate electrode and a second gate electrode, the first gate electrode is formed using a metal material with low resistance and the second gate electrode is formed using a metal oxide material that can reduce oxygen vacancies in an oxide semiconductor layer. The first gate electrode is connected to the scan line, and the second gate electrode is connected to a wiring to which a constant potential is supplied.

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Background/Summary

TECHNICAL FIELD

- (1) One embodiment of the present invention relates to a display device provided with a transistor including an oxide semiconductor.
- (2) Note that one embodiment of the present invention is not limited to the above technical field. The technical field of one embodiment of the invention disclosed in this specification and the like relates to an object, a method, or a manufacturing method. One embodiment of the present invention relates to a process, a machine, manufacture, or a composition of matter. In particular, one embodiment of the present invention relates to a semiconductor device, a display device, a light-emitting device, a power storage device, a storage device, a driving method thereof, or a manufacturing method thereof.

BACKGROUND ART

- (3) A technique for forming a transistor using a semiconductor layer formed over a substrate having an insulating surface (also referred to as a field-effect transistor (FET) or a thin film transistor (TFT)) has been attracting attention. The transistor is used in a wide range of electronic devices such as an integrated circuit (IC) and an image display device (display device). Semiconductor materials typified by silicon are widely known as materials for semiconductor layers that can be used for transistors. As other materials, oxide semiconductors have been attracting attention.
- (4) For example, a technique for forming a transistor using an amorphous oxide containing In, Zn, Ga, Sn, and the like as an oxide semiconductor is disclosed (see Patent Document 1). A technique for forming a self-aligned top-gate transistor using an oxide layer is also disclosed (see Patent Document 2). In addition, a technique for forming a transistor in which an oxide layer where a channel is formed is electrically surrounded by electric fields of top and bottom gate electrodes to achieve high field-effect mobility is disclosed (see Patent Document 3).
- (5) In addition, a technique for forming a transistor with high electrical reliability, e.g., a small shift in threshold voltage by using an insulating layer that releases oxygen by being heated as a base insulating layer of an oxide semiconductor layer where a channel is formed, to reduce oxygen vacancies in the oxide semiconductor layer is disclosed (see Patent Document 4).

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Patent Document

(6) [Patent Document 1] Japanese Published Patent Application No. 2006-165529 [Patent Document 2] Japanese Published Patent Application No. 2009-278115 [Patent Document 3] Japanese Published Patent Application No. 2014-241404 [Patent Document 4] Japanese Published Patent Application No. 2012-009836

DISCLOSURE OF INVENTION

- (7) Transistors including oxide layers are expected to be used for display devices. Such transistors are required to have high field-effect mobility and high reliability. To achieve high field-effect mobility, it is effective in a transistor to electrically surround an oxide layer where a channel is formed. However, there is a problem in that the gate capacitance of such a transistor in which an oxide layer where a channel is formed is electrically surrounded by electric fields of gate electrodes is excessively increased when the transistor is driven with a signal of a scan line.
- (8) To decrease gate capacitance, a single-gate structure, rather than a structure in which an oxide layer is surrounded by gate electrodes, is effectively used. However, the use of a gate electrode that is formed with, for example, an oxide layer and releases oxygen by being heated as a top gate to achieve high reliability causes a problem of increasing the resistance of the gate electrode, or the

resistance of a scan line, compared with the use of a gate electrode formed with metal.

- (9) Such a structure in which a gate electrode that releases oxygen by being heated is used as a top gate effectively allows a transistor to have high reliability. Therefore, to reduce the resistance of a scan line in this structure, it is effective to use a gate electrode formed with metal as a bottom gate and to form the scan line using a metal wiring on the bottom gate side. However, such a structure has a problem in that forming an opening for connecting a top gate and a bottom gate in a small region such as a pixel region makes the layout difficult, resulting in difficulty in fabricating a high-definition display device. Although a metal wiring can be stacked over a gate electrode that releases oxygen by being heated so that the resistance of a scan line is reduced, this structure has a problem in that the number of steps increases and thus the manufacturing cost increases.
- (10) In view of the above problems, an object of one embodiment of the present invention is to provide a novel display device or the like in which a transistor connected to a scan line has small gate capacitance. Another object of one embodiment of the present invention is to provide a novel display device or the like in which a scan line has low resistance. Another object of one embodiment of the present invention is to provide a novel display device or the like in which pixels can be arranged with high density. Another object of one embodiment of the present invention is to provide a novel display device or the like that can be manufactured without an increase in cost. (11) Note that the objects of one embodiment of the present invention are not limited to the above objects. The objects described above do not disturb the existence of other objects. The other objects are the ones that are not described above and will be described below. The other objects will be
- are the ones that are not described above and will be described below. The other objects will be apparent from and can be derived from the description of the specification, the drawings, and the like by those skilled in the art. One embodiment of the present invention achieves at least one of the aforementioned objects and the other objects.
- (12) One embodiment of the present invention is a display device including a first transistor, a second transistor, a first wiring, and a second wiring. The first transistor includes a first gate electrode, a second gate electrode, and a first semiconductor layer. The second transistor includes a first gate electrode, a second gate electrode, and a second semiconductor layer. The first wiring is configured to transmit a signal for controlling conduction states of the first transistor and the second transistor. The second wiring is configured to transmit a constant voltage. The first gate electrode of the first transistor and the first gate electrode of the second transistor are electrically connected to the first wiring. The second gate electrode of the first transistor and the second gate electrode of the second wiring. The first semiconductor layer and the second semiconductor layer include an oxide semiconductor. The first gate electrode of the first transistor include a metal material. The second gate electrode of the first transistor and the second gate electrode of the second transistor include a metal material.
- (13) One embodiment of the present invention is a display device including a first transistor, a second transistor, a third transistor, a first wiring, and a second wiring. The first transistor includes a first gate electrode, a second gate electrode, and a first semiconductor layer. The second transistor includes a first gate electrode, a second gate electrode, and a third semiconductor layer. The third transistor includes a first gate electrode, a second gate electrode, and a third semiconductor layer. The first wiring is configured to transmit a signal for controlling conduction states of the first transistor and the second transistor. The second wiring is configured to transmit a constant voltage. The first gate electrode of the first transistor and the first gate electrode of the second transistor are electrically connected to the first wiring. The second gate electrode of the first transistor and the second gate electrode of the third transistor are electrically connected to the third transistor and the second gate electrode of the third transistor are electrically connected to each other. The first semiconductor layer, the second semiconductor layer, and the third semiconductor layer include an oxide semiconductor. The first gate electrode of the first transistor, the first gate electrode of the second transistor, and the first gate electrode of the

third transistor include a metal material. The second gate electrode of the first transistor, the second gate electrode of the second transistor, and the second gate electrode of the third transistor include a metal oxide material.

- (14) One embodiment of the present invention is a display device including a first transistor, a second transistor, a third transistor, a capacitor, a light-emitting element, a first wiring, and a second wiring. The first transistor includes a first gate electrode, a second gate electrode, and a first semiconductor layer. The second transistor includes a first gate electrode, a second gate electrode, and a second semiconductor layer. The third transistor includes a first gate electrode, a second gate electrode, and a third semiconductor layer. The first wiring is configured to transmit a signal for controlling conduction states of the first transistor and the second transistor. The second wiring is configured to transmit a constant voltage. The first gate electrode of the first transistor and the first gate electrode of the second transistor are electrically connected to the first wiring. The second gate electrode of the first transistor and the second gate electrode of the second transistor are electrically connected to the second wiring. One of a source and a drain of the first transistor is electrically connected to the first gate electrode of the third transistor, one electrode of the capacitor, and the second gate electrode of the third transistor. One of a source and a drain of the second transistor is electrically connected to one of a source and a drain of the third transistor, the other electrode of the capacitor, and one electrode of the light-emitting element. The first semiconductor layer, the second semiconductor layer, and the third semiconductor layer include an oxide semiconductor. The first gate electrode of the first transistor, the first gate electrode of the second transistor, and the first gate electrode of the third transistor include a metal material. The second gate electrode of the first transistor, the second gate electrode of the second transistor, and the second gate electrode of the third transistor include a metal oxide material.
- (15) One embodiment of the present invention is a display device including a pixel electrically connected to a first wiring and a second wiring. The pixel includes a first transistor and a second transistor. The first transistor includes a first gate electrode, a second gate electrode, and a first semiconductor layer. The second transistor includes a first gate electrode, a second gate electrode, and a second semiconductor layer. The first wiring is configured to transmit a signal for controlling conduction states of the first transistor and the second transistor. The second wiring is configured to transmit a constant voltage. The first gate electrode of the first transistor and the first gate electrode of the second transistor are electrically connected to the first wiring. The second gate electrode of the second wiring. The first semiconductor layer and the second semiconductor layer include an oxide semiconductor. The first gate electrode of the first transistor and the first gate electrode of the second transistor include a metal material. The second gate electrode of the first transistor and the second gate electrode of the
- (16) In the display device of one embodiment of the present invention, the oxide semiconductor preferably includes oxygen, In, Zn, and M (M is Al, Ga, Y, or Sn).
- (17) In the display device of one embodiment of the present invention, the oxide semiconductor preferably includes a crystal part having c-axis alignment.
- (18) In the display device of one embodiment of the present invention, the metal oxide material preferably includes oxygen, In, Zn, and M (M is Al, Ga, Y, or Sn), and the metal oxide material preferably has a higher carrier density than the oxide semiconductor.
- (19) Note that other embodiments of the present invention will be described in the following embodiments with reference to the drawings.
- (20) One embodiment of the present invention can provide a novel display device or the like in which a transistor connected to a scan line has small gate capacitance. Another embodiment of the present invention can provide a novel display device or the like in which a scan line has low resistance. Another embodiment of the present invention can provide a novel display device or the like in which pixels can be arranged with high density. Another embodiment of the present

invention can provide a novel display device or the like that can be manufactured without an increase in cost.

(21) Note that the effects of one embodiment of the present invention are not limited to the above effects. The effects described above do not disturb the existence of other effects. The other effects are the ones that are not described above and will be described below. The other effects will be apparent from and can be derived from the description of the specification, the drawings, and the like by those skilled in the art. One embodiment of the present invention has at least one of the aforementioned effects and the other effects. Accordingly, one embodiment of the present invention does not have the aforementioned effects in some cases.

Description

BRIEF DESCRIPTION OF DRAWINGS

- (1) FIGS. **1**A and **1**B are a circuit diagram and a timing chart of a display device of one embodiment.
- (2) FIGS. **2**A to **2**C are a top view and cross-sectional views of a display device of one embodiment.
- (3) FIG. **3** is a top view of a display device of one embodiment.
- (4) FIG. **4** is a perspective view of a display device of one embodiment.
- (5) FIGS. **5**A and **5**B are cross-sectional views of a display device of one embodiment.
- (6) FIGS. **6**A and **6**B are top views of a display device of one embodiment.
- (7) FIGS. 7A and 7B are circuit diagrams of a display device of one embodiment.
- (8) FIGS. **8**A to **8**C are each a circuit diagram of a display device of one embodiment.
- (9) FIG. **9** illustrates a structure example of a display device of one embodiment.
- (10) FIG. **10** illustrates a structure example of a display device of one embodiment.
- (11) FIG. **11** illustrates a structure example of a display device of one embodiment.
- (12) FIG. 12 illustrates a structure example of a touch panel of one embodiment.
- (13) FIGS. **13**A to **13**D illustrate a method for manufacturing a display device of one embodiment.
- (14) FIGS. **14**A to **14**D illustrate the method for manufacturing a display device of one embodiment.
- (15) FIGS. **15**A to **15**D illustrate the method for manufacturing a display device of one embodiment.
- (16) FIGS. **16**A and **16**B illustrate the method for manufacturing a display device of one embodiment.
- (17) FIGS. **17**A to **17**C illustrate the method for manufacturing a display device of one embodiment.
- (18) FIGS. **18**A to **18**F illustrate electronic devices of embodiments.
- (19) FIGS. **19**A to **19**I illustrate electronic devices of embodiments.
- (20) FIGS. **20**A to **20**F illustrate electronic devices of embodiments.
- (21) FIGS. **21**A to **21**E illustrate electronic devices of embodiments.
- (22) FIGS. **22**A to **22**C illustrate electronic devices of embodiments.
- (23) FIG. **23** is an energy band diagram of a transistor including an oxide semiconductor film in a channel region.
- (24) FIGS. **24**A and **24**B are each a circuit diagram of a display device of one embodiment.
- (25) FIGS. **25**A to **25**B are each a circuit diagram of a display device of one embodiment.
- (26) FIGS. **26**A and **26**B are a block diagram and a circuit diagram of Example.
- (27) FIG. **27** is a top view of Example.
- BEST MODE FOR CARRYING OUT THE INVENTION
- (28) Embodiments and an example will be described in detail with reference to the drawings. Note

that the present invention is not limited to the following description. It will be readily appreciated by those skilled in the art that modes and details of the present invention can be modified in various ways without departing from the spirit and scope of the present invention. Thus, the present invention should not be construed as being limited to the description in the following embodiments and example.

- (29) Note that in structures of the present invention described below, the same portions or portions having similar functions are denoted by the same reference numerals in different drawings, and the description thereof is not repeated. The same hatching pattern is applied to portions having similar functions, and the portions are not especially denoted by reference numerals in some cases.
- (30) Note that in each drawing described in this specification, the size, the layer thickness, or the region of each component is exaggerated for clarity in some cases. Therefore, the size, the layer thickness, or the region is not necessarily limited to the illustrated scale.
- (31) Note that in this specification and the like, ordinal numbers such as "first" and "second" are used in order to avoid confusion among components and do not limit the number.
- (32) A transistor is a kind of semiconductor elements and can achieve amplification of current or voltage, switching operation for controlling conduction or non-conduction, or the like. A transistor in this specification includes, in its category, an insulated-gate field effect transistor (IGFET) and a thin film transistor (TFT).
- (33) Functions of a "source" and a "drain" are sometimes replaced with each other when a transistor of opposite polarity is used or when the direction of current flow is changed in circuit operation, for example. Therefore, the terms "source" and "drain" can be replaced with each other in this specification.

Embodiment 1

(34) In this embodiment, a configuration example of a display device of one embodiment of the present invention will be described.

Configuration Example of Circuit Diagram

- (35) FIG. **1**A is a circuit diagram of a pixel included in a display device.
- (36) A pixel PIX includes a transistor M1, a transistor M2, a transistor M3, a capacitor C1, and a light-emitting element EL. The pixel PIX is connected to a scan line GL, a signal line SL, a current supply line ANODE, a wiring V0, and a common wiring CATHODE. The pixel PIX corresponds to a subpixel included in a pixel that performs color display. Although description will be given assuming that the transistors M1 to M3 are n-channel transistors, the transistors M1 to M3 may be p-channel transistors.
- (37) The scan line GL is a wiring for supplying a scan signal to a pixel. A scan signal is a signal for controlling the conduction state of a transistor that is supplied with the scan signal. The signal line SL is a wiring for supplying a signal corresponding to image data to the pixel. The current supply line ANODE and the common wiring CATHODE are wirings for supplying current to the lightemitting element EL. The wiring V**0** is a wiring to which a constant voltage is applied. (38) In the transistors M1 and M2, gate electrodes are provided over and below a semiconductor layer. The gate electrode located below the semiconductor layer and formed using a metal material is referred to as a first gate electrode (also referred to as a bottom gate electrode). The gate electrode located over the semiconductor layer and formed using a metal oxide material is referred to as a second gate electrode (also referred to as a top gate electrode). Structure examples that can be used for the transistors M1 and M2 will be described later. Although the transistor M3 has the same structure as those of the transistors M1 and M2 in FIG. 1A, the structure of the transistor M3 is not limited thereto. Note that the metal oxide material includes a metal element and oxygen. (39) The first gate electrode of the transistor M1 is connected to the scan line GL. The second gate electrode of the transistor M1 is connected to the wiring V0. One of a source and a drain of the transistor M**1** is connected to the signal line SL. The other of the source and the drain of the

transistor M1 is connected to a first gate electrode and a second gate electrode of the transistor M3

- and one electrode of the capacitor C1.
- (40) The first gate electrode of transistor M2 is connected to the scan line GL. The second gate electrode of the transistor M2 is connected to the wiring V0. One of a source and a drain of the transistor M2 is connected to the wiring V0. The other of the source and the drain of the transistor M2 is connected to one of a source and a drain of the transistor M3, the other electrode of the capacitor C1, and one electrode of the light-emitting element EL.
- (41) The first gate electrode of the transistor M3 is connected to the other of the source and the drain of the transistor M1, the second gate electrode of the transistor M3, and the one electrode of the capacitor C1. The one of the source and the drain of the transistor M3 is connected to the other of the source and the drain of the transistor M2, the other electrode of the capacitor C1, and the one electrode of the light-emitting element EL. The other of the source and the drain of the transistor M3 is connected to the current supply line ANODE.
- (42) The one electrode of the capacitor C1 is connected to the other of the source and the drain of the transistor M1 and the first gate electrode and the second gate electrode of the transistor M3. The other electrode of the capacitor C1 is connected to the other of the source and the drain of the transistor M2, the one of the source and the drain of the transistor M3, and the one electrode of the light-emitting element EL.
- (43) The one electrode of the light-emitting element EL is connected to the other of the source and the drain of the transistor M2, the one of the source and the drain of the transistor M3, and the other electrode of the capacitor C1. The other electrode of the light-emitting element EL is connected to the common wiring CATHODE.
- (44) The scan line GL, to which the first gate electrode of the transistor M1 and the first gate electrode of the transistor M2 are connected, is formed with the metal material below the semiconductor layer. The scan line GL is connected to the first gate electrode of the transistor M1 and the first gate electrode of the transistor M2 without passing through an opening. The wiring V0, to which the second gate electrode of the transistor M1 and the second gate electrode of the transistor M2 are connected, is formed with a metal material included in a conductive layer above the transistors M1 and M2. The wiring V0 is connected to the second gate electrode of the transistor M1 and the second gate electrode of the transistor M2 through an opening.
- (45) FIG. **1**B is a timing chart briefly showing the operation of the circuit in FIG. **1**A. FIG. **1**B shows the voltage of the wiring V**0** and an image signal of the signal line SL in one scan line selection period (P.sub.SCAN) of a scan line GL(n) in an n-th row.
- (46) As shown in FIG. **1**B, the image signal of the signal line in SL in P.sub.SCAN is switched from a signal DATA(n-1) of a (n-1)-th row to a signal DATA(n) of the n-th row. During this period, the voltage of the wiring V**0** is a constant voltage V.sub.0.
- (47) In the above configuration, the first gate electrode and the second gate electrode are not connected to each other in the transistors M1 and M2. Owing to the configuration, the gate capacitance between the scan line GL and the transistors is formed only between the scan line GL and the first gate electrodes in contrast to the case where the first and second gate electrodes are connected to each other. The gate capacitance between the wiring V0 and the transistors M1 and M2 is negligible because the constant voltage is applied to the wiring V0. Thus, the above configuration can reduce the gate capacitance between the scan line GL and the transistors compared with the case where the first and second gate electrodes are connected to each other. Furthermore, by controlling the constant voltage V.sub.0 that is applied to the wiring V0, the threshold voltages of the transistors M1 and M2 can be adjusted.
- (48) Furthermore, in the above configuration, the scan line GL that is formed with the metal material can be provided in the same layer as the first gate electrode in the transistors M1 and M2. Thus, even when the first gate electrode is formed with a conductive layer including the metal material and the second gate electrode is formed with a conductive layer including the metal oxide material such as an oxide semiconductor, a problem of an increase in the resistance of the scan line

- GL can be avoided. Moreover, manufacturing cost can be reduced by the cost for providing an extra wiring using a metal material to reduce the resistance of the scan line GL.
- (49) Since in the above configuration, the first gate electrode can be formed with the conductive layer including the metal material and the second gate electrode can be formed with the conductive layer including the metal oxide material such as an oxide semiconductor, a gate electrode that releases oxygen by being heated is used as the second gate electrode, so that the reliability of the transistors can be improved. In addition, since the first gate electrode and the second gate electrode are not connected to each other in the transistors M1 and M2, which means that the gate electrodes are not connected to each other in a small region such as a pixel region, a high-definition display device can be fabricated.

Structure Example of Transistor

- (50) Here, a structure example of a transistor that can be used for the transistors M1 and M2 will be described with reference to FIGS. 2A to 2C.
- (51) FIGS. **2**A to **2**C illustrate an example of a semiconductor device including a transistor. Note that the transistor illustrated in FIGS. **2**A to **2**C has a structure in which gate electrodes are provided over and below a semiconductor layer.
- (52) FIG. **2**A is a top view of a transistor **100**. FIG. **2**B is a cross-sectional view taken along the dashed-dotted line X**1**-X**2** in FIG. **2**A. FIG. **2**C is a cross-sectional view taken along the dashed-dotted line Y**1**-Y**2** in FIG. **2**A. For clarity, some components such as an insulating layer **110** are not illustrated in FIG. **2**A. As in FIG. **2**A, some components are not illustrated in some cases in top views of transistors described below. In addition, the direction of the dashed-dotted line X**1**-X**2** may be referred to as the channel length (L) direction, and the direction of the dashed-dotted line Y**1**-Y**2** may be referred to as the channel width (W) direction.
- (53) The transistor **100** illustrated in FIGS. **2**A to **2**C includes a conductive layer **106** formed over a substrate **102**, an insulating layer **104** formed over the conductive layer **106**, an oxide semiconductor layer **108** over the insulating layer **104**, the insulating layer **110** over the oxide semiconductor layer **108**, an oxide semiconductor layer **112** over the insulating layer **110**, and an insulating layer **116** over the insulating layer **104** and the oxide semiconductor layers **108** and **112**. Furthermore, the oxide semiconductor layer **108** has a channel region **108***i* in contact with the insulating layer **116**, and a drain region **108***d* in contact with the insulating layer **116**.
- (54) The transistor **100** may further include a conductive layer **120***a* electrically connected to the source region **108***s* through an opening **141***a* formed in the insulating layer **116**, and a conductive layer **120***b* electrically connected to the drain region **108***d* through an opening **141***b* formed in the insulating layer **116**.
- (55) The conductive layer **106** functions as a first gate electrode and is formed using a metal material. The oxide semiconductor layer **112** functions as a second gate electrode and is formed using a metal oxide material. The insulating layer **104** functions as a first gate insulating layer, and the insulating layer **110** functions as a second gate insulating layer.
- (56) The insulating layer **116** includes one or both of nitrogen and hydrogen. From the insulating layer **116** including nitrogen and/or hydrogen, nitrogen and/or hydrogen can be supplied to the oxide semiconductor layer **108** and the oxide semiconductor layer **112**.
- (57) As the insulating layer **116**, for example, a nitride insulating layer can be used. The nitride insulating layer can be formed using silicon nitride, silicon nitride oxide, aluminum nitride, aluminum nitride oxide, or the like. The hydrogen concentration in the insulating layer **116** is preferably higher than or equal to 1×10.sup.22 atoms/cm.sup.3.
- (58) The oxide semiconductor layer **112** has a function of supplying oxygen to the insulating layer **110**. The oxide semiconductor layer **112** having a function of supplying oxygen to the insulating layer **110** enables the insulating layer **110** to contain excess oxygen. When the insulating layer **110** includes an excess oxygen region, excess oxygen can be supplied to the oxide semiconductor layer

- **108**, specifically, the channel region **108***i*. Therefore, a semiconductor device with high reliability can be provided.
- (59) The insulating layer **110** can be formed to have a single-layer structure or layered structure using an oxide insulating layer or a nitride insulating layer. For example, the insulating layer **110** can be formed to have a single-layer structure or layered structure using silicon oxide, silicon oxynitride, silicon nitride oxide, silicon nitride, aluminum oxide, hafnium oxide, gallium oxide, a Ga—Zn oxide, or the like.
- (60) Since the insulating layer **110** formed over the oxide semiconductor layer **108** contains excess oxygen, excess oxygen can be selectively supplied to the channel region **108***i*. Alternatively, after excess oxygen is supplied to the channel region **108***i*, the source region **108***s*, and the drain region **108***d*, the carrier density in the source region **108***s* and the drain region **108***d* may be selectively increased.
- (61) Note that the thickness of the insulating layer **110** is preferably smaller than that of the insulating layer **104**. As described above, the constant voltage is applied from the wiring V**0** to the oxide semiconductor layer **112** functioning as a second gate electrode. The small thickness of the insulating layer **110** allows large parasitic capacitance to be formed in the transistor **100** by the second gate electrode, the second gate insulating layer, and the oxide semiconductor layer **108**. This can suppress the dielectric breakdown of the transistor due to static discharge or the like. (62) The carrier density in the oxide semiconductor layer **112** having supplied oxygen to the insulating layer **110** is increased by nitrogen and/or hydrogen supplied from the insulating layer **116**. In other words, the oxide semiconductor layer **112** also functions as an oxide conductor (OC). Thus, the oxide semiconductor layer **112** has a higher carrier density than the oxide semiconductor layer **108**.
- (63) Furthermore, the oxide semiconductor layer **112** and the source region **108**s and the drain region **108**d of the oxide semiconductor layer **108** may each include an element that forms an oxygen vacancy. Typical examples of the element that forms an oxygen vacancy are hydrogen, boron, carbon, nitrogen, fluorine, phosphorus, sulfur, chlorine, and a rare gas element. Typical examples of the rare gas element are helium, neon, argon, krypton, and xenon.
- (64) An impurity element added to the oxide semiconductor layer cuts a bond between a metal element and oxygen in the oxide semiconductor layer, so that an oxygen vacancy is formed. Alternatively, when an impurity element is added to the oxide semiconductor layer, oxygen bonded to a metal element in the oxide semiconductor layer is bonded to the impurity element and released from the metal element, so that an oxygen vacancy is formed. As a result, the oxide semiconductor layer has a higher carrier density, and thus, the conductivity thereof becomes higher.
- (65) The transistor **100** preferably includes a region in which a side end portion of the insulating layer **110** is aligned with a side end portion of the oxide semiconductor layer **112**. In other words, in the transistor **100**, an upper end portion of the insulating layer **110** is substantially aligned with a lower end portion of the oxide semiconductor layer **112**. The above structure can be obtained by processing the insulating layer **110** with the use of the oxide semiconductor layer **112** as a mask, for example.
- (66) The oxide semiconductor layer **108** and the oxide semiconductor layer **112** are each formed using a metal oxide such as In-M-Zn oxide (M is Al, Ga, Y, or Sn). Alternatively, In—Ga oxide or In—Zn oxide may each be used for the oxide semiconductor layer **108** and the oxide semiconductor layer **112**. It is particularly preferred that the oxide semiconductor layer **108** and the oxide semiconductor layer **112** be formed using metal oxides containing the same elements because the manufacturing cost can be reduced.
- (67) In the case where the oxide semiconductor layers $\mathbf{108}$ and $\mathbf{112}$ are each an In-M-Zn oxide, it is preferred that the atomic ratio of metal elements of a sputtering target used to form a layer of the In-M-Zn oxide satisfy In \geq M and Zn \geq M. As the atomic ratio of metal elements in such a sputtering target, In:M:Zn=1:1:1, In:M:Zn=1:1:1.2, In:M:Zn=2:1:1.5, In:M:Zn=2:1:2.3, In:M:Zn=2:1:3,

In:M:Zn=3:1:2, In:M:Zn=4:2:4.1, In:M:Zn=5:1:7, or the like is preferable. Note that the atomic ratios of metal elements in the formed oxide semiconductor layers 108 and 112 may vary from the above atomic ratio of metal elements of the sputtering target within a range of approximately ±40%. For example, when a sputtering target with the atomic ratio of In:Ga:Zn=4:2:4.1 is used, an atomic ratio of In:Ga:Zn in the oxide semiconductor layer may be 4:2:3 and its vicinity. (68) When an oxide semiconductor layer with a low impurity concentration and a low density of defect states is used in the channel region **108***i*, the transistor can have more excellent electrical characteristics. Here, the state in which the impurity concentration is low and the density of defect states is low (the amount of oxygen vacancies is small) is referred to as "highly purified intrinsic" or "substantially highly purified intrinsic". It is also possible to call this state "intrinsic" or "substantially intrinsic". A highly purified intrinsic or substantially highly purified intrinsic oxide semiconductor has few carrier generation sources, and thus has a low carrier density in some cases. Thus, a transistor including the oxide semiconductor layer in which a channel region is formed is likely to have a positive threshold voltage (normally-off characteristics). A highly purified intrinsic or substantially highly purified intrinsic oxide semiconductor layer has a low density of defect states and accordingly has a low density of trap states in some cases. Furthermore, a highly purified intrinsic or substantially highly purified intrinsic oxide semiconductor layer has an extremely low off-state current. Thus, a transistor whose channel region is formed in the oxide semiconductor layer has a small variation in electrical characteristics and high reliability in some cases. (69) Meanwhile, the source region **108**s, the drain region **108**d, and the oxide semiconductor layer **112** are in contact with the insulating layer **116**. Hydrogen and/or nitrogen are/is added from the insulating layer **116** to the source region **108**s, the drain region **108**d, and the oxide semiconductor layer **112** in contact with the insulating layer **116**, so that the carrier densities in the source region **108**s, the drain region **108***d*, and the oxide semiconductor layer **112** are increased. (70) The carrier density of an oxide semiconductor layer will be described below. (71) Examples of a factor that affects the carrier density of an oxide semiconductor layer include oxygen vacancies (Vo) and impurities in the oxide semiconductor layer. (72) As the amount of oxygen vacancies in the oxide semiconductor layer increases, the density of defect states increases when hydrogen is bonded to the oxygen vacancies (this state is also referred to as VoH). The density of defect states also increases with an increase in the amount of impurities in the oxide semiconductor layer. Hence, the carrier density of the oxide semiconductor layer can be adjusted by controlling the density of defect states in the oxide semiconductor layer. (73) A transistor using the oxide semiconductor layer in a channel region will be described. (74) The carrier density of the oxide semiconductor layer is preferably reduced in order to suppress the negative shift of the threshold voltage of the transistor or reduce the off-state current of the transistor. In order to reduce the carrier density of the oxide semiconductor layer, the impurity concentration in the oxide semiconductor layer is reduced so that the density of defect states can be reduced. In this specification and the like, the state in which the impurity concentration is low and the density of defect states is low is referred to as "highly purified intrinsic" or "substantially highly purified intrinsic". The carrier density of a highly purified intrinsic oxide semiconductor layer is lower than 8×10.sup.15 cm.sup.-3, preferably lower than 1×10.sup.11 cm.sup.-3, more preferably lower than 1×10.sup.10 cm.sup.-3and is higher than or equal to 1×10.sup.-9 cm.sup.-3. (75) In contrast, the carrier density of the oxide semiconductor layer is preferably increased in order to increase the on-state current of the transistor or improve the field-effect mobility of the transistor. In order to increase the carrier density of the oxide semiconductor layer, it is preferred that the impurity concentration or the density of defect states in the oxide semiconductor layer be slightly increased, or the bandgap of the oxide semiconductor layer be narrowed. For example, an oxide semiconductor layer that has a slightly high impurity concentration or a slightly high density of defect states in the range where a favorable on/off ratio is obtained in the Id-Vg characteristics of a transistor can be regarded as substantially intrinsic. Furthermore, an oxide semiconductor layer

- that has a high electron affinity and a narrow bandgap and thus has an increased density of thermally excited electrons (carriers) can be regarded as substantially intrinsic. Note that a transistor using an oxide semiconductor layer with higher electron affinity has a lower threshold voltage.
- (76) The oxide semiconductor layer with an increased carrier density has somewhat n-type conductivity; thus, it can be referred to as a "slightly-n" oxide semiconductor layer.
- (77) The carrier density of a substantially intrinsic oxide semiconductor layer is preferably higher than or equal to 1×10.sup.5 cm.sup.-3 and lower than 1×10.sup.18 cm.sup.-3, more preferably higher than or equal to 1×10.sup.7 cm.sup.-3 and lower than or equal to 1×10.sup.17 cm.sup.-3, still more preferably higher than or equal to 1×10.sup.9 cm.sup.-3 and lower than or equal to 5×10.sup.16 cm.sup.-3, yet more preferably higher than or equal to 1×10.sup.10 cm.sup.-3 and lower than or equal to 1×10.sup.16 cm.sup.-3 and yet still more preferably higher than or equal to 1×10.sup.11 cm.sup.-3 and lower than or equal to 1×10.sup.15 cm.sup.-3.
- (78) The use of the substantially intrinsic oxide semiconductor layer described above may improve the reliability of the transistor. Here, the reason why the transistor including the oxide semiconductor layer in a channel region has high reliability will be described with reference to FIG. **23**. FIG. **23** is an energy band diagram of the transistor including the oxide semiconductor layer in the channel region.
- (79) In FIG. 23, GE stands for a gate electrode, GI stands for a gate insulating film, OS stands for an oxide semiconductor layer, and SD stands for a source electrode or a drain electrode. That is to say, FIG. 23 is an example of the energy band of the gate electrode, the gate insulating film, the oxide semiconductor layer, and the source electrode or the drain electrode in contact with the oxide semiconductor layer.
- (80) In FIG. 23, a silicon oxide film is used as the gate insulating film, and an In—Ga—Zn oxide is used for the oxide semiconductor layer. In addition, it is assumed that the transition level £f of a defect that can be formed in the silicon oxide film is located approximately 3.1 eV apart from the conduction band minimum of the gate insulating film, and the Fermi level Ef of the silicon oxide film at the interface between the oxide semiconductor layer and the silicon oxide film when the gate voltage Vg is 30 V is located approximately 3.6 eV apart from the conduction band minimum of the gate insulating film. Note that the Fermi level Ef of the silicon oxide film varies depending on the gate voltage. For example, as the gate voltage is increased, the Fermi level Ef of the silicon oxide film at the interface between the oxide semiconductor layer and the silicon oxide film becomes low. In FIG. 23, hollow circles indicate electrons (carriers), and symbols "X" indicate defect states in the silicon oxide film.
- (81) As illustrated in FIG. 23, for example, when the carriers are thermally excited under application of the gate voltage, the carriers are trapped in the defect states ("X" in the diagram), and the charge state of the defect states is changed from positive ("+") to neutral ("0"). Specifically, in the case where the value obtained by adding the thermal excitation energy to the Fermi level Ef of the silicon oxide film becomes greater than the transition level ɛf of the defect, the charge state of the defect states in the silicon oxide film is changed from positive to neutral, and the threshold voltage of the transistor is positively shifted.
- (82) When an oxide semiconductor layer with a different electron affinity is used, the Fermi level of the interface between the gate insulating film and the oxide semiconductor layer might be changed. When an oxide semiconductor layer with a greater electron affinity is used, the conduction band minimum of the gate insulating film is relatively high at the interface between the gate insulating film and the oxide semiconductor layer or in the vicinity of the interface. In that case, the defect states ("X" in FIG. 23) that can be formed in the gate insulating film are also located in a relatively high position; thus, the energy difference between the Fermi level of the gate insulating film and the Fermi level of the oxide semiconductor film is increased. This results in less charge trapped in the gate insulating film. For example, a change in the charge states of the defect

- states that can be formed in the silicon oxide film is smaller; thus, a change in the threshold voltage of the transistor due to gate bias temperature (GBT) stress can be smaller.
- (83) The above is the description of the carrier density of the oxide semiconductor layer.
- (84) As illustrated in FIG. **2**C, the oxide semiconductor layer **108***i* faces the conductive layer **106** functioning as a first gate electrode and the oxide semiconductor layer **112** functioning as a second gate electrode. That is, the oxide semiconductor layer **108***i* is positioned between the conductive layer and the oxide semiconductor layer which function as gate electrodes.
- (85) Such a structure enables the oxide semiconductor layer **108** included in the transistor **100** to be electrically surrounded by an electric field due to a scan signal of the conductive layer **106** functioning as a first gate electrode and an electric field due to the constant voltage of the oxide semiconductor layer **112** functioning as a second gate electrode.
- (86) In the transistor **100**, a scan signal for controlling the conduction state of the transistor **100** is supplied from the first gate electrode and the constant voltage is applied from the second gate electrode as illustrated in FIG. **1**A. Since the constant voltage is applied to the wiring V**0**, the gate capacitance between the wiring V**0** and the transistors M**1** and M**2** is negligible, and the gate capacitance between the scan line GL and the transistors can be reduced compared with the case where the first and second gate electrodes are connected to each other.
- (87) Furthermore, the conduction state of the transistor **100** is controlled by the scan line provided in the same layer as the first gate electrode. The first gate electrode is formed using the metal material. The metal material has a lower resistance than the metal oxide material of the oxide semiconductor layer **112** functioning as a second gate electrode, or the like. Thus, the resistance of the scan line formed using the same material as that of the conductive layer **106** can be low. (88) Furthermore, the transistor **100** includes the oxide semiconductor layer **112** functioning as a second gate electrode as a gate electrode that releases oxygen by being heated like an oxide layer. Thus, the transistor **100** has high reliability. Since the resistance of the conductive layer **106** functioning as a first gate electrode and the scan line located in the same layer as the conductive layer **106** can be reduced as described above, a disadvantage, high resistance of the second gate electrode, can be offset. Moreover, the number of steps can be reduced compared with the structure in which an oxide semiconductor layer and a metal wiring are stacked to reduce the resistance of the oxide semiconductor layer functioning as a second gate electrode; consequently, the manufacturing cost can be reduced.
- (89) Furthermore, the transistor **100** does not have an opening for connecting the first gate electrode and the second gate electrode. This can avoid the necessity for providing an opening in a small region like a pixel region. Thus, the transistor **100** is suitable for a high-definition display device.

Example of Topside Structure

- (90) Next, FIG. **3** is an example of a top view that can be used for the circuit configuration in FIG. **1**A except the structure of a light-emitting element and the like. FIG. **4** illustrates the state where a conductive layer, a semiconductor layer, and the like arranged up and down in the top view of FIG. **3** are separately shown and connected through openings. FIG. **5**A is a cross-sectional view along the dotted line P**1**-P**2** in FIG. **3**, and FIG. **5**B is a cross-sectional view along the dotted line Q**1**-Q**2** in FIG. **3**. FIGS. **6**A and **6**B are top views in which the top views of FIG. **3** including the structure of the light-emitting element and the like are arranged.
- (91) In the top view of FIG. 3, the scan line GL, the signal line SL, the wiring V0, the current supply line ANODE, the transistor M1, the transistor M2, a transistor M3, and the capacitor C1 are illustrated. Insulating layers and the like in the layered structure of the conductive layer and the oxide semiconductor layer are not illustrated.
- (92) The layered structure of the oxide semiconductor layer and the conductive layer forming the wirings and the like in FIG. 3 can be understood from FIG. 4 and FIGS. 5A and 5B. A conductive layer 151 and a conductive layer 152 functioning as first gate electrodes are provided over a

substrate SUB. Then, an oxide semiconductor layer **161**, an oxide semiconductor layer **162**, and an oxide semiconductor layer **163** are provided thereover with an insulating layer **153** functioning as a first gate insulating layer therebetween. In addition, an oxide semiconductor layer 171, an oxide semiconductor layer 172, and an oxide semiconductor layer 173 functioning as second gate electrodes are provided thereover with an insulating layer **164** functioning as a second gate insulating layer therebetween. Then, a conductive layer **181**, a conductive layer **182**, a conductive layer **183**, a conductive layer **184**, and a conductive layer **185** functioning as source and drain electrodes of transistors and wirings are provided thereover with an insulating layer 174 therebetween. The insulating layer **174** selectively increases the carrier densities in the oxide semiconductor layer **161**, the oxide semiconductor layer **162**, and the oxide semiconductor layer **163** and the carrier densities in the oxide semiconductor layer **171**, the oxide semiconductor layer **172**, and the oxide semiconductor layer **173** to increase the conductivity of the oxide semiconductor layers. In addition, a conductive layer 191 and a conductive layer 192 are provided over the conductive layers 181, 182, 183, 184, and 185 with an insulating layer 186 and an insulating layer **187** functioning as interlayer insulating layers therebetween. An insulating layer **193** functioning as an interlayer insulating layer is provided over the conductive layers **191** and **192**. In addition, an opening **190** is formed in the insulating layers **186**, **187**, and **193** so as to reach the conductive layer **183**. The opening **190** is for connection between a pixel electrode formed later and a light-emitting element provided over the pixel electrode.

- (93) In FIGS. **3** and **4**, squares with crosses indicate openings formed in the insulating layers. The conductive layers and the oxide semiconductor layers in separate layers are connected through the openings as shown by arrows in FIG. **4**. In FIG. **4**, the conductive layer **151** functioning as the scan line GL, the conductive layer **191** functioning as the signal line SL, the conductive layer **181** functioning as the wiring V**0**, and the conductive layer **192** functioning as the current supply line ANODE are illustrated.
- (94) As seen from FIG. **3**, FIG. **4**, and FIGS. **5**A and **5**B, the first gate electrode and the second gate electrode are not connected to each other in the transistors M**1** and M**2**. Owing to the configuration, the gate capacitance between the scan line GL and the transistors M**1** and M**2** is formed only between the scan line GL and the first gate electrodes in contrast to the case where the first and second gate electrodes are connected to each other. Thus, the above configuration can reduce the gate capacitance between the scan line GL and the transistors compared with the case where the first and second gate electrodes are connected to each other.
- (95) Furthermore, as seen from FIG. **3**, FIG. **4**, and FIGS. **5**A and **5**B, the scan line GL that is formed with the metal material can be provided in the same layer as the first gate electrode in the transistors M**1** and M**2**. Thus, even when the first gate electrode is formed with a conductive layer including the metal material and the second gate electrode is formed with a conductive layer including the metal oxide material such as an oxide semiconductor, a problem of an increase in the resistance of the scan line GL can be avoided. Moreover, manufacturing cost can be reduced by the cost for providing an extra wiring using a metal material to reduce the resistance of the scan line GL.
- (96) In addition, as seen from FIG. **3**, FIG. **4**, and FIGS. **5**A and **5**B, two electrodes of the capacitor C**1** can be formed using the conductive layer **152** and the oxide semiconductor layer **163**. Reducing the thickness of the insulating layer **153** between the two electrodes can increase the capacitance of the capacitor.
- (97) FIG. **6**A is a top view of 2×3 subpixels for three colors (e.g., red (R), green (G), and blue (B)), each of which corresponds to the pixel illustrated in FIG. **3**, FIG. **4**, and FIGS. **5**A and **5**B. FIG. **6**A illustrates subpixels (R**1**, R**2**, G**1**, G**2**, B**1**, and B**2**) arranged in two rows, an m-th row and an (m+1)-th row; and three columns, an n-th column, an (n+1)-th column, and an (n+2)-th column. FIG. **6**A also illustrates a light-emitting layer **198** included in a light-emitting element EL and a partition layer **199** as well as the opening **190** described with reference to FIG. **3** to FIGS. **5**A and

- **5**B. FIG. **6**A also illustrates a scan line GL_m in the m-th row, a scan line GL_m+1 in the (m+1)-th row; a signal line SL_n in the n-th column, a signal line SL_n+1 in the (n+1)-th column, a signal line SL_n+2 in the (n+2)-th column, the wiring V**0**, and the current supply line ANODE.
- (98) FIG. **6**B is a schematic diagram of the top view in FIG. **6**A. In FIG. **6**B, the light-emitting layer **198**, the partition layer **199**, and the like are provided in a region **22**, and a circuit including the transistors M**1** and M**3** and the like are provided in a region **24**. As illustrated also in FIG. **6**A, the opening **190** is located in the vicinity of the center of the region **24**. The region **24** is located so as not to be aligned with the region **22**, whereby the opening **190** can be located at an end portion of the region **22**. This structure allows a light-emitting region to be provided regardless of the position of the opening **190**.

Modification Example

- (99) A circuit configuration for which one embodiment of the present invention can be used is not limited to the pixel configuration including the transistors M1 to M3 in FIG. 1A. For example, one embodiment of the present invention can also be used for a pixel configuration including two or less transistors as in FIG. 7A.
- (100) The pixel configuration illustrated in FIG. 7A includes a transistor M4, a transistor M5, a capacitor C2, and the light-emitting element EL. That is, the pixel configuration corresponds to the circuit configuration in FIG. 1A without the transistor M2.
- (101) Also in the configuration illustrated in FIG. 7A, a first gate electrode and a second gate electrode are not connected to each other in the transistor M4. Owing to the configuration, the gate capacitance between the scan line GL and the transistors is formed only between the scan line GL and the first gate electrodes in contrast to the case where the first and second gate electrodes are connected to each other. The gate capacitance between the wiring V0 and the transistor M4 is negligible because the constant voltage is applied to the wiring V0. Thus, the above configuration can reduce the gate capacitance between the scan line GL and the transistors compared with the case where the first and second gate electrodes are connected to each other. Furthermore, by controlling the constant voltage that is applied to the wiring V0, the threshold voltage of the transistor M4 can be adjusted.
- (102) Furthermore, in the above configuration, the scan line GL that is formed with the metal material can be provided in the same layer as the first gate electrode in the transistor M4. Thus, even when the first gate electrode is formed with a conductive layer including the metal material and the second gate electrode is formed with a conductive layer including the metal oxide material such as an oxide semiconductor, a problem of an increase in the resistance of the scan line GL can be avoided. Moreover, manufacturing cost can be reduced by the cost for providing an extra wiring using a metal material to reduce the resistance of the scan line GL.
- (103) Since in the above configuration, the first gate electrode can be formed with the conductive layer including the metal material and the second gate electrode can be formed with the conductive layer including the metal oxide material such as an oxide semiconductor, a gate electrode that releases oxygen by being heated is used as the second gate electrode, so that the reliability of the transistors can be improved. In addition, since the first gate electrode and the second gate electrode are not connected to each other in the transistor M4, which means that the gate electrodes are not connected to each other in a small region such as a pixel region, a high-definition display device can be fabricated.
- (104) A circuit configuration for which one embodiment of the present invention can be used is not limited to the pixel configurations in FIG. 1A and FIG. 7A. For example, one embodiment of the present invention can also be used for a pixel configuration including three or more transistors as in FIG. 7B.
- (105) The pixel configuration illustrated in FIG. 7B includes a transistor M6, a transistor M7, a transistor M8, a transistor M9, a transistor M10, a transistor M11, a capacitor C3, a capacitor C4, a capacitor C5, and the light-emitting element EL. The pixel with this configuration is operated by

the signal line SL, the current supply line ANODE, the wiring V**0**, the common wiring CATHODE, scan lines GL**1** to GL**4**, and wirings V**1** and V**2**. The wirings V**1** and V**2** are each a wiring to which a constant voltage is applied.

- (106) Also in the configuration illustrated in FIG. 7B, a first gate electrode and a second gate electrode are not connected to each other in the transistors M6 to M10. Owing to the configuration, the gate capacitance between the scan lines GL1 to GL4 and the transistors is formed only between the scan lines GL1 to GL4 and the first gate electrodes in contrast to the case where the first and second gate electrodes are connected to each other. The gate capacitance between the wiring V0 and the transistors M6 to M10 is negligible because the constant voltage is applied to the wiring V0. Thus, the above configuration can reduce the gate capacitance between the scan lines GL1 to GL4 and the transistors compared with the case where the first and second gate electrodes are connected to each other. Furthermore, by controlling the constant voltage that is applied to the wiring V0, the threshold voltage of the transistors M6 to M10 can be adjusted.
- (107) Furthermore, in the above configuration, the scan lines GL1 to GL4 that are formed with the metal material can be provided in the same layer as the first gate electrode in the transistors M6 to M10. Thus, even when the first gate electrode is formed with a conductive layer including the metal material and the second gate electrode is formed with a conductive layer including the metal oxide material such as an oxide semiconductor, a problem of an increase in the resistance of the scan lines GL1 to GL4 can be avoided. Moreover, manufacturing cost can be reduced by the cost for providing an extra wiring using a metal material to reduce the resistance of the scan lines GL1 to GL4.
- (108) Since in the above configuration, the first gate electrode can be formed with the conductive layer including the metal material and the second gate electrode can be formed with the conductive layer including the metal oxide material such as an oxide semiconductor, a gate electrode that releases oxygen by being heated is used as the second gate electrode, so that the reliability of the transistors can be improved. In addition, since the first gate electrode and the second gate electrode are not connected to each other in the transistors M6 to M10, which means that the gate electrodes are not connected to each other in a small region such as a pixel region, a high-definition display device can be fabricated.
- (109) Although the first gate electrode and the second gate electrode of the transistor M3 are not connected to each other in FIG. 1A, one embodiment of the present invention is not limited to this configuration. For example, the second gate electrode of the transistor M3 may be connected to the wiring V0 as illustrated in FIG. 8A.
- (110) Alternatively, for example, the first gate electrode of the transistor M3 may be omitted as illustrated in FIG. 8B. Alternatively, for example, the first gate electrode of the transistor M3 may be connected to one of a source and a drain of the transistor M3 as illustrated in FIG. 8C. (111) Also in the configurations illustrated in FIGS. 8A to 8C, the first gate electrode and the second gate electrode are not connected to each other in the transistors M1 and M2. Owing to the configuration, the gate capacitance between the scan line GL and the transistors is formed only between the scan line GL and the first gate electrodes in contrast to the case where the first and second gate electrodes are connected to each other. The gate capacitance between the wiring V0 and the transistors M1 and M2 is negligible because the constant voltage is applied to the wiring V0. Thus, the above configuration can reduce the gate capacitance between the scan line GL and the transistors compared with the case where the first and second gate electrodes are connected to each other. Furthermore, by controlling the constant voltage that is applied to the wiring V0, the threshold voltages of the transistors M1 and M2 can be adjusted.
- (112) Furthermore, in the above configuration, the scan line GL that is formed with the metal material can be provided in the same layer as the first gate electrode in the transistors M1 and M2. Thus, even when the first gate electrode is formed with a conductive layer including the metal material and the second gate electrode is formed with a conductive layer including the metal oxide

- material such as an oxide semiconductor, a problem of an increase in the resistance of the scan line GL can be avoided. Moreover, manufacturing cost can be reduced by the cost for providing an extra wiring using a metal material to reduce the resistance of the scan line GL.
- (113) Since in the above configuration, the first gate electrode can be formed with the conductive layer including the metal material and the second gate electrode can be formed with the conductive layer including the metal oxide material such as an oxide semiconductor, a gate electrode that releases oxygen by being heated is used as the second gate electrode, so that the reliability of the transistors can be improved. In addition, since the first gate electrode and the second gate electrode are not connected to each other in the transistors M1 and M2, which means that the gate electrodes are not connected to each other in a small region such as a pixel region, a high-definition display device can be fabricated.
- (114) Although both the second gate electrodes of the transistors M1 and M2 are connected to the wiring V0 in FIG. 1A, one embodiment of the present invention is not limited to this configuration. For example, as illustrated in FIG. 24A, the second gate electrode of the transistor M1 may be connected to the wiring V0, and the second gate electrode of the transistor M2 may be connected to the scan line GL. This configuration can increase the current supply capability of the transistor M2. (115) Alternatively, as illustrated in FIG. 24B, the second gate electrode of the transistor M2 may be connected to the wiring V0, and the second gate electrode of the transistor M1 may be connected to the scan line GL. This configuration can increase the current supply capability of the transistor M1.
- (116) Furthermore, instead of the scan line GL in FIG. **1**A, the plurality of scan lines GL**1** and GL**2** may be provided. For example, as illustrated in FIG. **25**A, the first gate electrode of the transistor M**1** may be connected to the scan line GL**1**, and the first gate electrode of the transistor M**2** may be connected to the scan line GL**2**.
- (117) Furthermore, instead of the wiring $V\mathbf{0}$ in FIG. **1**A, a plurality of wirings $V\mathbf{0}_{-}\mathbf{1}$ and $V\mathbf{0}_{-}\mathbf{2}$ may be provided. For example, as illustrated in FIG. **25**B, the second gate electrode of the transistor M**1** may be connected to the wiring $V\mathbf{0}_{-}\mathbf{1}$, and the second gate electrode of the transistor M**2** may be connected to the wiring $V\mathbf{0}_{-}\mathbf{1}$.
- (118) At least part of this embodiment can be implemented in combination with any of the other embodiments described in this specification as appropriate.

Embodiment 2

(119) In this embodiment, an example of a cross-sectional structure of a display device of one embodiment of the present invention will be described.

Structure Example of Display Device

(120) FIG. **9** is a schematic top view of a display device **10** described below. The display device **10** includes a pixel portion **11**, a scan line driver circuit **12**, a signal line driver circuit **13**, a terminal portion **15**, a plurality of wirings **16***a*, a plurality of wirings **16***b*, and the like.

Cross-Sectional Structure Example 1-1

- (121) FIG. **10** is a schematic cross-sectional view of the display device **10**. FIG. **10** shows a cross section taken along the section line A**1**-A**2** of FIG. **9**.
- (122) The display device **10** includes a first substrate **201** and a second substrate **202** which are bonded to each other with a bonding layer **220**.
- (123) The terminal portion **15**, the wiring **16***b*; a transistor **255** that is included in the signal line driver circuit **13**, transistors **251** and **252**, a capacitor **253**, and a light-emitting element **254** that are included in the pixel portion **11**, and the like are provided over the first substrate **201**. In addition, insulating layers **211**, **212**, **213**, and **214**, a spacer **215**, and the like are provided over the first substrate **201**.
- (124) On the first substrate **201** side of the second substrate **202**, an insulating layer **221**, a light-blocking layer **231**, a coloring layer **232**, structures **230***a* and **230***b*, and the like are provided. (125) The light-emitting element **254** is provided over the insulating layer **213**. The light-emitting

- element **254** includes a pixel electrode **225** serving as a first electrode, an EL layer **222**, and a second electrode **223**. An optical adjustment layer **224** is provided between the pixel electrode **225** and the EL layer **222**. The insulating layer **214** covers end portions of the pixel electrode **225** and the optical adjustment layer **224**.
- (126) The transistor **251** functions as the transistor M**1** or M**2** described in Embodiment 1 with reference to FIG. **1**A. The transistor **252** functions as the transistor M**3** described in Embodiment 1 with reference to FIG. **1**A.
- (127) The transistor **251**, the transistor **252**, and a transistor **255** are provided with a conductive layer **275** functioning as a first gate electrode and a conductive layer **272** functioning as a second gate electrode. Specifically, a semiconductor in which a channel is formed is sandwiched between the two gate electrodes. The conductive layer **275** corresponds to the conductive layer **106** functioning as a first gate electrode described in Embodiment 1 with reference to FIGS. **2**A to **2**C. The conductive layer **272** corresponds to the oxide semiconductor layer **112** functioning as a second gate electrode described in Embodiment 1 with reference to FIGS. **2**A to **2**C. (128) When the conductive layer **275** is used as an electrode that releases oxygen so that oxygen vacancies in the semiconductor layer **271** can be filled, the electrical characteristics of the

transistors can be stable.

- (129) In the transistor connected to a light-emitting element, like the transistor **252**, two gate electrodes are preferably electrically connected to each other so as to be supplied with the same signal. Such a transistor can have higher field-effect mobility and thus have higher on-state current than other transistors. Consequently, a circuit capable of high-speed operation can be obtained. (130) Although the capacitor **253** is formed of part of a conductive layer **274**, part of an insulating layer **217**, and part of a conductive layer **273** as illustrated in FIG. **10**, the capacitor **253** can be formed of part of the conductive layer **275**, part of the insulating layer **211**, and part of the semiconductor layer **271**.
- (131) The light-emitting element **254** in the example illustrated in FIG. **10** is a top-emission light-emitting element. Light emission from the light-emitting element **254** is extracted from the second substrate **202** side. Such a structure enables the transistors, the capacitors, the circuits, the wirings, and the like to be provided below the light-emitting element **254** (i.e., on the first substrate **201** side), leading to an increase in the aperture ratio of the pixel portion **11**.
- (132) The coloring layer **232** overlapping with the light-emitting element **254** is provided on the surface of the second substrate **202** on the first substrate **201** side. The light-blocking layer **231** may be provided in a region where the coloring layer **232** is not provided. The light-blocking layer **231** may overlap with the signal line driver circuit **13** as illustrated in FIG. **10**. In addition, a light-transmitting overcoat layer may be provided to cover the coloring layer **232** and the light-blocking layer **231**.
- (133) On the first substrate **201** side of the second substrate **202**, the structure **230***a* is located inward from the bonding layer **220**, and the structure **230***b* is located outward from the bonding layer **220**. The structures **230***a* and **230***b* each have a function of suppressing development of a crack in the insulating layer **221**, the second substrate **202**, or the like at the end portions of the second substrate **202**. The structures **230***a* and **230***b* in the example of FIG. **10** have layered structures including a layer formed of the same film as the light-blocking layer **231** and a layer formed of the same film as the coloring layer **232**. Such a layered structure including two or more layers can increase the effect of suppressing crack development. Although the structures **230***a* and **230***b* are provided on both sides of the bonding layer **220**, either one of the structures **230***a* and **230***b* may be provided on one side of the bonding layer **220**. When there is no possibility of cracks (e.g., when the second substrate **202** possesses high stiffness), the structures **230***a* and **230***b* may be omitted.
- (134) The spacer **215** is provided over the insulating layer **214**. The spacer **215** serves as a gap spacer for preventing the distance between the first substrate **201** and the second substrate **202** from

excessively decreasing. The angle between part of the side surface of the spacer **215** and the surface where the spacer **215** is formed is preferably more than or equal to 45° and less than or equal to 120°, more preferably more than or equal to 60° and less than or equal to 100°, still more preferably more than or equal to 75° and less than or equal to 90°. Owing to this structure, a region of the EL layer **222** with a small thickness can be easily formed on the side surface of the spacer **215**. This can prevent undesired emission due to a current that flows through the EL layer **222** between adjacent light-emitting elements. Providing the spacer **215** having such a shape between light-emitting elements is effective particularly when the pixel portion **11** has high definition because the distance between adjacent light-emitting elements is reduced. Furthermore, that is effective particularly when the EL layer **222** includes a layer containing highly conductive material, for example.

- (135) In the case where a blocking mask is used in the formation of the EL layer **222**, the second electrode **223**, and the like, the spacer **215** may have a function of protecting the formation surface from flaws due to the blocking mask.
- (136) The spacer **215** preferably overlaps with the wiring which intersects with a scan line.
- (137) A color filter method is used for the display device **10** shown in FIG. **10**. For example, a structure in which one color is expressed by subpixels each including the coloring layer **232** of any of red (R), green (G), and blue (B) may be used. In addition, subpixels for white (W) and yellow (Y) are preferably used because the color reproducibility can be improved and power consumption can be reduced.
- (138) Owing to the combination of the coloring layer **232** and a microcavity structure using the optical adjustment layer **224** in the light-emitting element **254**, light with high color purity can be extracted from the display device **10**. The thickness of the optical adjustment layer **224** is determined depending on the color of a subpixel. The optical adjustment layer may be omitted in some subpixels.
- (139) An EL layer that emits white light is preferably used as the EL layer **222** of the light-emitting element **254**. The use of the light-emitting element **254** eliminates the need of separately coloring the EL layers **222** of the subpixels, which leads to a reduction in cost and an increase in yield. In addition, the pixel portion **11** can be easily formed with high resolution. The subpixels may include optical adjustment layers having different thicknesses so that the EL layers **222** in the subpixels are separately colored, in which case one or both of the optical adjustment layer and the coloring layer can be omitted. In that case, layers in the subpixels are not necessarily colored separately except light-emitting layers of the EL layers **222**.
- (140) In the example shown in FIG. **10**, an FPC **242** is electrically connected to the terminal portion **15**. Thus, the display device **10** shown in FIG. **10** can be referred to as a display module. A display device without an FPC or the like can be referred to as a display panel.
- (141) The terminal portion **15** is electrically connected to the FPC **242** through the connection layer **243**.
- (142) The terminal portion **15** shown in FIG. **10** has a layered structure including the wiring **16***b* and a conductive layer formed of the same conductive film as the pixel electrode **225**. The terminal portion **15** preferably has a layered structure including a plurality of conductive layers because not only a reduction in electric resistance but also an increase in mechanical strength can be achieved. (143) It is preferred that the insulating layer **211** and the insulating layer **221** be formed using a material through which impurities such as water and hydrogen do not easily diffuse. That is, the insulating layer **211** and the insulating layer **221** can serve as barrier films. With such a structure, entry of impurities from the outside into the light-emitting element **254**, the transistors, and the like can be effectively inhibited even when a moisture-permeable material is used for the first substrate **201** and the second substrate **202**, which leads to a highly reliable display device.
- (144) The example shown in FIG. **10** has a sealed hollow structure including a space **250** between the first substrate **201** and the second substrate **202**. For example, the space **250** may be filled with

an inert gas such as nitrogen or a rare gas. The space **250** may be filled with a fluid material such as oil, or the pressure in the space **250** may be reduced. The sealing method is not limited thereto, and solid sealing using a resin or the like may be used.

Cross-Sectional Structure Example 2

- (145) FIG. **11** is a structure example of a display device which is suitable when the pixel portion **11** and the signal line driver circuit **13** are bent and used.
- (146) The display device **10** shown in FIG. **11** has a solid sealing structure in which the first substrate **201** and the second substrate **202** are bonded to each other with a sealant **260**.
- (147) A bonding layer **261** is provided over the first substrate **201**. An insulating layer **216** is provided over the bonding layer **261**. A transistor, a light-emitting element, and the like are provided over the insulating layer **216**. The insulating layer **216** is preferably formed using a material through which impurities such as water or hydrogen do not easily diffuse, like the insulating layer **221**.
- (148) A bonding layer **262** is provided between the second substrate **202** and the insulating layer **221**.
- (149) As shown in FIG. 11, the insulating layer 213 has an opening located in a portion closer to the outer end of the first substrate 201 than the pixel portion 11 and the signal line driver circuit 13. It is preferable to form an opening in the insulating layer 213 formed using a resin material, for example, so as to surround the pixel portion 11, the signal line driver circuit 13, and the like. In such a structure, the vicinity of the side surface of the insulating layer 213 which is in contact with the outside of the display device 10 does not form a continuous layer with the region overlapping with the pixel portion 11, the signal line driver circuit 13, and the like, so that diffusion of impurities, such as water and hydrogen, from the outside through the insulating layer 213 can be inhibited.
- (150) The solid sealing structure shown in FIG. **11** makes it easier to keep the distance between the first substrate **201** and the second substrate **202** constant. Thus, flexible substrates can be preferably used as the first substrate **201** and the second substrate **202**. As a result, part of or the whole of the pixel portion **11**, the scan line driver circuit **12**, and the signal line driver circuit **13** can be bent when used. For example, the display device **10** can be bonded to a curved surface or the pixel portion of the display device **10** can be folded to produce electronic devices with a variety of structures.

Modification Example

- (151) An example of a touch panel including a touch sensor will be described below.
- (152) FIG. **12** shows an example of a touch panel in which an on-cell touch sensor is used in the structure shown as an example in FIG. **10**.
- (153) Over the second substrate **202**, a conductive layer **291** and a conductive layer **292** are covered with an insulating layer **294**. A conductive layer **293** is provided over the insulating layer **294**. The conductive layer **293** is electrically connected, through an opening of the insulating layer **294**, to two conductive layers **292** between which the conductive layer **291** is provided. The insulating layer **294** is bonded to a substrate **296** with a bonding layer **295**.
- (154) The amount of the capacitance formed between the conductive layers **291** and **292** changes with the approach of an object, so that the approach or contact of the object can be sensed. A lattice arrangement of the plurality of conductive layers **291** and the plurality of conductive layers **292** allows location information to be obtained.
- (155) A terminal portion **299** is provided in the vicinity of the outer end of the second substrate **202**. The terminal portion **299** is electrically connected to an FPC **297** through a connection layer **298**.
- (156) The substrate **296** here can be used also as a substrate with which an object, such as a finger or a stylus, is to be in contact. In that case, a protective layer (such as a ceramic coat) is preferably provided over the substrate **296**. The protective layer can be formed using an inorganic insulating

material such as silicon oxide, aluminum oxide, yttrium oxide, or yttria-stabilized zirconia (YSZ). Alternatively, tempered glass may be used as the substrate **296**. Physical or chemical processing by an ion exchange method, a wind tempering method, or the like may be performed on tempered glass so that compressive stress is applied on the surface. In the case where the touch sensor is provided on one side of tempered glass and the opposite side of the tempered glass is provided on, for example, the outermost surface of an electronic device for use as a touch surface, the thickness of the whole device can be decreased.

- (157) As the touch sensor, a capacitive touch sensor can be used. Examples of the capacitive touch sensor are a surface capacitive touch sensor and a projected capacitive touch sensor. Examples of the projected capacitive touch sensor include a self-capacitive touch sensor and a mutual capacitive touch sensor. The use of a mutual capacitive type is preferable because multiple points can be sensed simultaneously. An example of using a projected capacitive touch sensor will be described below.
- (158) Note that one embodiment of the present invention is not limited to this example, and any of a variety of sensors capable of sensing the approach or contact of an object, such as a finger or a stylus, can be used.
- (159) The above example shows an on-cell touch panel in which a wiring and the like composing a touch sensor are formed on the outer surface of the second substrate **202**; there is no need to limit to the structure. For example, an external touch panel or an in-cell touch panel can be employed. The use of the on-sell or in-cell touch panel allows a reduction in the thickness of a display panel even when the display panel has a touch-panel function.
- (160) The above is the description of the cross-sectional structure examples.

Components

(161) The above components will be described below.

Substrate

- (162) A substrate having a flat surface can be used as the substrate included in the display device. The substrate through which light emitted from the light-emitting element is extracted is formed using a material that transmits the light. For example, a material such as glass, quartz, ceramic, sapphire, or an organic resin can be used.
- (163) The weight and thickness of the display device can be reduced using a thin substrate. Furthermore, a flexible display device can be obtained using a substrate that is thin enough to have flexibility.
- (164) As the glass, for example, alkali-free glass, barium borosilicate glass, aluminoborosilicate glass, or the like can be used.
- (165) Examples of a material having flexibility and transmitting visible light include glass that is thin enough to have flexibility, polyester resins such as polyethylene terephthalate (PET) and polyethylene naphthalate (PEN), a polyacrylonitrile resin, a polyimide resin, a polymethyl methacrylate resin, a polycarbonate (PC) resin, a polyethersulfone (PES) resin, a polyamide resin, a cycloolefin resin, a polystyrene resin, a polyamide imide resin, a polyvinyl chloride resin, and a polytetrafluoroethylene (PTFE) resin. In particular, a material whose thermal expansion coefficient is low is preferred, and for example, a polyamide imide resin, a polyimide resin, or PET can be suitably used. Alternatively, a substrate in which a glass fiber is impregnated with an organic resin or a substrate whose thermal expansion coefficient is reduced by mixing an organic resin with an inorganic filler can be used. A substrate using such a material is lightweight, and thus, a display device using this substrate can also be lightweight.
- (166) Since the substrate through which light is not extracted does not need to have a light-transmitting property, a metal substrate or the like can be used, other than the above-mentioned substrates. A metal substrate, which has high thermal conductivity, is preferable because it can easily conduct heat to the whole substrate and accordingly can prevent a local temperature rise in the display device.

- (167) Although there is no particular limitation on a material of the metal substrate, it is preferable to use, for example, a metal such as aluminum, copper, or nickel, or an alloy such as an aluminum alloy or stainless steel.
- (168) It is possible to use a substrate subjected to insulation treatment in such a manner that a surface of a metal substrate is oxidized or an insulating film is formed on a surface. An insulating film may be formed by, for example, a coating method such as a spin-coating method or a dipping method, an electrodeposition method, an evaporation method, or a sputtering method. An oxide film may be formed on the substrate surface by an anodic oxidation method, exposure to or heating in an oxygen atmosphere, or the like.
- (169) A hard coat layer (e.g., a silicon nitride layer) by which a surface of the display device is protected from damage, a layer (e.g., an aramid resin layer) that can disperse pressure, or the like may be stacked over the flexible substrate. Furthermore, to suppress a decrease in the lifetime of the light-emitting element due to moisture and the like, an insulating film with low water permeability may be stacked over the flexible substrate. For example, an inorganic insulating material such as silicon nitride, silicon oxynitride, aluminum oxide, or aluminum nitride can be used.
- (170) The substrate may be formed by stacking a plurality of layers. In particular, when a glass layer is used, a barrier property against water and oxygen can be improved, and thus, a highly reliable display device can be provided. For example, a substrate in which a glass layer, a bonding layer, and an organic resin layer are stacked in this order from the side closer to the light-emitting element can be used. By providing such an organic resin layer, a crack or a break in the glass layer can be suppressed and mechanical strength can be improved. The use of such a composite material of a glass material and an organic resin for the substrate enables fabrication of a highly reliable and flexible display device.

Transistor

- (171) The transistor included in the display device includes a conductive layer functioning as a front gate electrode, a conductive layer functioning as a back gate electrode, the semiconductor layer, a conductive layer functioning as a source electrode, a conductive layer functioning as a drain electrode, and an insulating layer functioning as a gate insulating layer.
- (172) That is, in the transistor included in the display device of one embodiment of the present invention, gate electrodes are provided over and under a channel.
- (173) There is no particular limitation on the crystallinity of a semiconductor material used for the transistor, and an amorphous semiconductor or a semiconductor having crystallinity (a microcrystalline semiconductor, a polycrystalline semiconductor, a single crystal semiconductor, or a semiconductor partly including crystal regions) may be used. A semiconductor having crystallinity is preferably used, in which case deterioration of the transistor characteristics can be suppressed.
- (174) As a semiconductor material used for the semiconductor layer of the transistor, an oxide semiconductor can be used, for example. In particular, an oxide semiconductor having a wider band gap than silicon is preferably used. A semiconductor material having a wider band gap and a lower carrier density than silicon is preferably used because the off-state current of the transistor can be reduced.
- (175) For example, the oxide semiconductor preferably contains at least indium (In) or zinc (Zn). The oxide semiconductor more preferably includes an In-M-Zn-based oxide (M is a metal such as A1, Ti, Ga, Ge, Y, Zr, Sn, La, Ce, or Hf).
- (176) As the semiconductor layer, it is particularly preferable to use an oxide semiconductor layer including a plurality of crystal parts whose c-axes are aligned substantially perpendicularly to a surface on which the semiconductor layer is formed or the top surface of the semiconductor layer and in which a grain boundary is not observed between adjacent crystal parts.
- (177) There is no grain boundary in such an oxide semiconductor; therefore, generation of a crack

- in an oxide semiconductor layer which is caused by stress when a display panel is bent is prevented. Consequently, such an oxide semiconductor can be preferably used for a flexible display device which is used in a bent state, or the like.
- (178) Moreover, the use of such an oxide semiconductor with crystallinity for the semiconductor layer makes it possible to provide a highly reliable transistor in which a variation in electrical characteristics is suppressed.
- (179) A transistor with an oxide semiconductor whose band gap is larger than that of silicon can hold charge accumulated in a capacitor that is serially-connected to the transistor for a long time, owing to the low off-state current of the transistor. When such a transistor is used for a pixel, operation of a driver circuit can be stopped while the gray scale of each pixel is maintained. As a result, a display device with extremely low power consumption can be obtained. Conductive Layer
- (180) As materials for the gates, the source, and the drain of a transistor, and the conductive layers serving as the wirings and electrodes included in the display device, any of metals such as aluminum, titanium, chromium, nickel, copper, yttrium, zirconium, molybdenum, silver, tantalum, and tungsten, or an alloy containing any of these metals as its main component can be used. A single-layer structure or a layered structure including a film containing any of these materials can be used. For example, the following structures can be given: a single-layer structure of an aluminum film containing silicon, a two-layer structure in which an aluminum film is stacked over a titanium film, a two-layer structure in which an aluminum film is stacked over a tungsten film, a two-layer structure in which a copper film is stacked over a copper-magnesium-aluminum alloy film, a two-layer structure in which a copper film is stacked over a titanium film, a two-layer structure in which a copper film is stacked over a tungsten film, a three-layer structure in which a titanium film or a titanium nitride film, an aluminum film or a copper film, and a titanium film or a titanium nitride film are stacked in this order, and a three-layer structure in which a molybdenum film or a molybdenum nitride film, an aluminum film or a copper film, and a molybdenum film or a molybdenum nitride film are stacked in this order. Note that an oxide such as indium oxide, tin oxide, or zinc oxide may be used. Copper containing manganese is preferably used because controllability of a shape by etching is increased.
- (181) As a light-transmitting material that can be used for the conductive layers serving as the wirings and electrodes in the display device, a conductive oxide such as indium oxide, indium tin oxide, indium zinc oxide, zinc oxide, or zinc oxide to which gallium is added, or graphene can be used. Alternatively, a metal material such as gold, silver, platinum, magnesium, nickel, tungsten, chromium, molybdenum, iron, cobalt, copper, palladium, or titanium or an alloy material containing any of these metal materials can be used. Alternatively, a nitride of the metal material (e.g., titanium nitride) or the like may be used. In the case of using the metal material or the alloy material (or the nitride thereof), the thickness is set small enough to allow light transmission. Alternatively, a layered film of any of the above materials can be used as the conductive layer. For example, a layered film of indium tin oxide and an alloy of silver and magnesium is preferably used because the conductivity can be increased.

Insulating Layer

- (182) As an insulating material that can be used for the insulating layers, the overcoat, the spacer, and the like, a resin such as acrylic or epoxy, a resin having a siloxane bond, such as a silicone resin, or an inorganic insulating material such as silicon oxide, silicon oxynitride, silicon nitride oxide, silicon nitride, or aluminum oxide can be used.
- (183) The light-emitting element is preferably provided between a pair of insulating films with low water permeability, in which case entry of impurities such as water into the light-emitting element can be inhibited. Thus, a decrease in device reliability can be suppressed.
- (184) As an insulating film with low water permeability, a film containing nitrogen and silicon, such as a silicon nitride film or a silicon nitride oxide film, a film containing nitrogen and

aluminum, such as an aluminum nitride film, or the like can be used. Alternatively, a silicon oxide film, a silicon oxynitride film, an aluminum oxide film, or the like may be used.

(185) For example, the amount of water vapor transmission of the insulating film with low water permeability is lower than or equal to 1×10.sup.-5 [g/(m.sup.2.Math.day)], preferably lower than or equal to 1×10.sup.-6 [g/(m.sup.2.Math.day)], more preferably lower than or equal to 1×10.sup.-7 [g/(m.sup.2.Math.day)], still more preferably lower than or equal to 1×10.sup.-8 [g/(m.sup.2.Math.day)].

Bonding Layer, Sealant

- (186) As the bonding layer and the sealant, a variety of curable adhesives, e.g., a photo-curable adhesive such as an ultraviolet curable adhesive, a reactive curable adhesive, a thermosetting curable adhesive, and an anaerobic adhesive can be used. Examples of these adhesives include an epoxy resin, an acrylic resin, a silicone resin, a phenol resin, a polyimide resin, an imide resin, a polyvinyl chloride (PVC) resin, a polyvinyl butyral (PVB) resin, and an ethylene vinyl acetate (EVA) resin. In particular, a material with low moisture permeability, such as an epoxy resin, is preferred. Alternatively, a two-component-mixture-type resin may be used. Still alternatively, an adhesive sheet or the like may be used.
- (187) Furthermore, the resin may include a drying agent. For example, a substance that adsorbs moisture by chemical adsorption, such as oxide of an alkaline earth metal (e.g., calcium oxide or barium oxide), can be used. Alternatively, a substance that adsorbs moisture by physical adsorption, such as zeolite or silica gel, may be used. The drying agent is preferably included because it can inhibit entry of impurities such as moisture into a functional element, leading to an improvement in the reliability of the display panel.
- (188) In addition, a filler with a high refractive index or a light-scattering member may be mixed into the resin, in which case the efficiency of light extraction from the light-emitting element can be improved. For example, titanium oxide, barium oxide, zeolite, or zirconium can be used. Light-Emitting Element
- (189) As the light-emitting element, a self-luminous element can be used, and an element whose luminance is controlled by current or voltage is included in the category of the light-emitting element. For example, a light-emitting diode (LED), an organic EL element, or an inorganic EL element can be used.
- (190) The light-emitting element may be a top emission, bottom emission, or dual emission light-emitting element. A conductive film that transmits visible light is used as the electrode through which light is extracted. A conductive film that reflects visible light is preferably used as the electrode through which light is not extracted.
- (191) The EL layer includes at least a light-emitting layer. In addition to the light-emitting layer, the EL layer may further include a layer containing any of a substance with a high hole-injection property, a substance with a high hole-transport property, a hole-blocking material, a substance with a high electron-transport property, a substance with a high electron-injection property, a substance with a high electron- and hole-transport property), and the like.
- (192) For the EL layer, either a low-molecular compound or a high-molecular compound can be used, and an inorganic compound may alternatively be used. The layers included in the EL layer can be formed by any of the following methods: an evaporation method (including a vacuum evaporation method), a transfer method, a printing method, an inkjet method, a coating method, and the like.
- (193) When a voltage higher than the threshold voltage of the light-emitting element is applied between a cathode and an anode, holes are injected to the EL layer from the anode side and electrons are injected to the EL layer from the cathode side. The injected electrons and holes are recombined in the EL layer and a light-emitting substance contained in the EL layer emits light. (194) In the case where a light-emitting element emitting white light is used as the light-emitting

element, the EL layer preferably contains two or more kinds of light-emitting substances. For example, light-emitting substances are selected such that two or more light-emitting substances emit complementary colors to obtain white light emission. Specifically, it is preferable to use two or more light-emitting substances selected from light-emitting substances emitting light of red (R), green (G), blue (B), yellow (Y), orange (O), and the like and light-emitting substances emitting light containing two or more of spectral components of R, G, and B. The light-emitting element preferably emits light with a spectrum having two or more peaks in the wavelength range of a visible light region (e.g., 350 nm to 750 nm). The emission spectrum of a material that emits light having a peak in a yellow wavelength range preferably includes spectral components also in green and red wavelength ranges.

(195) A light-emitting layer containing a light-emitting material that emits light of one color and a light-emitting layer containing a light-emitting material that emits light of another color are preferably stacked in the EL layer. For example, the plurality of light-emitting layers in the EL layer may be stacked in contact with each other or may be stacked with a region not including any light-emitting material therebetween. For example, between a fluorescent layer and a phosphorescent layer, a region containing the same material as that in the fluorescent layer or phosphorescent layer (for example, a host material or an assist material) and no light-emitting material may be provided. This facilitates the manufacture of the light-emitting element and reduces the drive voltage.

(196) The light-emitting element may be a single element including one EL layer or a tandem element in which a plurality of EL layers are stacked with a charge generation layer therebetween. (197) For the conductive film that transmits visible light, for example, indium oxide, indium tin oxide (ITO), indium zinc oxide, zinc oxide, or zinc oxide to which gallium is added can be used. Alternatively, a film of a metal material such as gold, silver, platinum, magnesium, nickel, tungsten, chromium, molybdenum, iron, cobalt, copper, palladium, or titanium, an alloy containing any of these metal materials, a nitride of any of these metal materials (e.g., titanium nitride), or the like can be used when formed thin enough to have a light-transmitting property. Alternatively, a layered film of any of the above materials can be used as the conductive layer. For example, a layered film of ITO and an alloy of silver and magnesium is preferably used because the conductivity can be increased. Still alternatively, graphene or the like may be used. (198) For the conductive film that reflects visible light, for example, a metal material such as aluminum, gold, platinum, silver, nickel, tungsten, chromium, molybdenum, iron, cobalt, copper, or palladium or an alloy containing any of these metal materials can be used. Lanthanum, neodymium, germanium, or the like may be added to the metal material or the alloy. Alternatively, an alloy containing aluminum (an aluminum alloy), such as an alloy of aluminum and titanium, an alloy of aluminum and nickel, or an alloy of aluminum and neodymium, or an alloy containing silver, such as an alloy of silver and copper, an alloy of silver, palladium, and copper, or an alloy of silver and magnesium can be used for the conductive film. An alloy containing silver and copper is preferable because of its high heat resistance. Furthermore, when a metal film or a metal oxide film is stacked in contact with an aluminum alloy film, oxidation of the aluminum alloy film can be suppressed. Examples of a material for the metal film or the metal oxide film include titanium and titanium oxide. Alternatively, the above conductive film that transmits visible light and a film containing a metal material may be stacked. For example, a layered film of silver and ITO or a layered film of an alloy of silver and magnesium and ITO can be used.

(199) The conductive layers may each be formed by an evaporation method or a sputtering method. Alternatively, a discharging method such as an inkjet method, a printing method such as a screen printing method, or a plating method may be used.

(200) Note that the aforementioned light-emitting layer and layers containing a substance with a high hole-injection property, a substance with a high hole-transport property, a substance with a high electron-transport property, a substance with a high electron-injection property, a substance

with a bipolar property, and the like may include an inorganic compound such as a quantum dot or a high molecular compound (e.g., an oligomer, a dendrimer, and a polymer). For example, when used for the light-emitting layer, the quantum dot can function as a light-emitting material. (201) The quantum dot may be a colloidal quantum dot, an alloyed quantum dot, a core-shell quantum dot, a core quantum dot, or the like. A quantum dot containing elements belonging to Groups 12 and 16, elements belonging to Groups 13 and 15, or elements belonging to Groups 14 and 16 may be used. Alternatively, a quantum dot containing an element such as cadmium, selenium, zinc, sulfur, phosphorus, indium, tellurium, lead, gallium, arsenic, or aluminum may be used.

Coloring Layer

(202) Examples of a material that can be used for the coloring layers include a metal material, a resin material, and a resin material containing a pigment or dye.

Light-Blocking Layer

(203) Examples of a material that can be used for the light-blocking layer include carbon black, a metal oxide, and a composite oxide containing a solid solution of a plurality of metal oxides. A stack of films containing the material for the coloring layer can also be used for the light-blocking layer. For example, a layered structure of a film containing a material of a coloring layer which transmits light of a certain color and a film containing a material of a coloring layer which transmits light of another color can be employed. It is preferred that the coloring layer and the light-blocking layer be formed using the same material because the same manufacturing apparatus can be used and the process can be simplified.

Connection Layer

- (204) As a connection layer connecting an FPC or an IC and a terminal, an anisotropic conductive film (ACF), an anisotropic conductive paste (ACP), or the like can be used.
- (205) The above is the description of the components.
- (206) At least part of this embodiment can be implemented in combination with any of the other embodiments described in this specification as appropriate.

Embodiment 3

- (207) In this embodiment, an example of a manufacturing method of a display device including a flexible substrate will be described.
- (208) Here, layers including a light-emitting element, a circuit, a wiring, an electrode, an insulating layer, optical members such as a coloring layer and a light-blocking layer, and the like are collectively referred to as an element layer. The element layer includes, for example, a light-emitting element, and may additionally include a wiring electrically connected to the light-emitting element or an element such as a transistor used in a pixel or a circuit.
- (209) In addition, here, a flexible member which supports the element layer at a stage at which the light-emitting element is completed (the manufacturing process is finished) is referred to as a substrate. Examples of the substrate include an extremely thin film with a thickness greater than or equal to 10 nm and less than or equal to 300 µm and the like.
- (210) As a method for forming an element layer over a flexible substrate provided with an insulating surface, typically, there are two methods shown below. One of them is to directly form an element layer over a flexible substrate. The other method is to form an element layer over a support substrate that is different from a flexible substrate and then to separate the element layer from the support substrate to transfer the element layer to the substrate. In addition to the above two methods, there is a method in which an element layer is formed over a substrate which does not have flexibility and the substrate is thinned by polishing or the like to have flexibility, though the details are not described here.
- (211) In the case where a material of the substrate can withstand heating temperature in a process for forming the element layer, It is preferred that the element layer be formed directly over the substrate, in which case a manufacturing process can be simplified. At this time, the element layer

is preferably formed in a state where the substrate is fixed to the support substrate, in which case transfer thereof in an apparatus and between apparatuses can be easy.

- (212) In the case of employing the method in which the element layer is formed over a support substrate and then transferred to a substrate, first, a separation layer and an insulating layer are stacked over the support substrate, and then the element layer is formed over the insulating layer. Next, the element layer is separated from the support substrate and then transferred to the substrate. At this time, a material is selected such that separation occurs at the interface between the support substrate and the separation layer, at the interface between the separation layer and the insulating layer, or in the separation layer. In the method, It is preferred that a material having high heat resistance be used for the support substrate or the separation layer, in which case the upper limit of the temperature applied when the element layer is formed can be higher, and an element layer including a more reliable element can be formed.
- (213) For example, a stacked layer of a layer containing a high-melting-point metal material, such as tungsten, and a layer containing an oxide of the metal material is used as the separation layer. Furthermore, a stacked layer of a plurality of layers, such as a silicon oxide layer, a silicon nitride layer, a silicon oxynitride layer, a silicon nitride oxide layer, and the like is preferably used as the insulating layer over the separation layer. Note that in this specification, oxynitride contains more oxygen than nitrogen, and nitride oxide contains more nitrogen than oxygen.
- (214) The element layer and the support substrate can be separated by applying mechanical force, by etching the separation layer, by making a liquid permeate the separation interface, or the like. Alternatively, separation can be performed by heating or cooling two layers of the separation interface to utilize a difference in thermal expansion coefficient.
- (215) When separation is started, It is preferred that a separation trigger be formed first so that the separation proceeds from the trigger. The separation trigger can be formed, for example, by locally heating part of the insulating layer or the separation layer with laser light or the like or by physically cutting or making a hole through part of the insulating layer or the separation layer with a sharp tool.
- (216) The separation layer is not necessarily provided in the case where the separation can be performed at the interface between the support substrate and the insulating layer. For example, glass is used for the support substrate and an organic resin such as polyimide is used for the insulating layer, in which case separation can be performed at the interface between the glass and the organic resin. The remaining organic resin such as polyimide can be used for the substrate. (217) Alternatively, a heat generation layer may be provided between the support substrate and the insulating layer formed of an organic resin, and separation may be performed at the interface between the heat generation layer and the insulating layer by heating the heat generation layer. As the heat generation layer, any of a variety of materials such as a material that generates heat by current supply, a material that generates heat by absorbing light, and a material that generates heat by application of a magnetic field can be used. For example, a semiconductor, a metal, or an insulator can be selected for the heat generation layer.
- (218) An example of a specific manufacturing method will be described below. The manufacturing method described below enables fabrication of a flexible input/output device of one embodiment of the present invention by changing a layer formed as a layer to be separated.
- (219) First, a formation substrate **301** is provided with an island-shaped separation layer **303**. Then, the separation layer **303** is provided with a layer **305** to be separated (FIG. **13**A). In addition, a formation substrate **321** is provided with an island-shaped separation layer **323**. Then, the separation layer **323** is provided with a layer **325** to be separated (FIG. **13**B).
- (220) Although an example in which the separation layer is formed to have an island shape is described here, one embodiment of the present invention is not limited to this example. In this step, as the material for the separation layer, a material that allows separation at the interface between the formation substrate and the separation layer, the interface between the separation layer and the

layer to be separated, or in the separation layer when the layer to be separated is separated from the formation substrate. Although an example in which separation occurs at the interface between the separation layer and the layer to be separated is described in this embodiment, one embodiment of the present invention is not limited to such an example and depends on materials used for the separation layer and the layer to be separated. Note that in the case where the layer to be separated has a layered structure, a layer in contact with the separation layer is particularly referred to as a first layer.

- (221) For example, when the separation layer has a layered structure of a tungsten film and a tungsten oxide film and separation occurs at the interface between the tungsten film and the tungsten oxide film (or the vicinity of the interface), part of the separation layer (here, part of the tungsten oxide film) may remain on the separated layer. Moreover, the separation layer remaining on the separated layer may be removed after separation.
- (222) As the formation substrate, a substrate having at least heat resistance enough to withstand process temperature in a manufacturing process is used. As the formation substrate, for example, a glass substrate, a quartz substrate, a sapphire substrate, a semiconductor substrate, a ceramic substrate, a metal substrate, a resin substrate, or a plastic substrate can be used.
- (223) In the case where a glass substrate is used as the formation substrate, an insulating film such as a silicon oxide film, a silicon oxynitride film, a silicon nitride film, or a silicon nitride oxide film is preferably formed as a base film between the formation substrate and the separation layer, in which case contamination from the glass substrate can be prevented.
- (224) The separation layer can be formed using an element selected from tungsten, molybdenum, titanium, tantalum, niobium, nickel, cobalt, zirconium, zinc, ruthenium, rhodium, palladium, osmium, iridium, and silicon; an alloy material containing any of the elements; a compound material containing any of the elements; or the like. The crystal structure of a layer containing silicon may be amorphous, microcrystalline, or polycrystalline. Alternatively, a metal oxide such as aluminum oxide, gallium oxide, zinc oxide, titanium dioxide, indium oxide, indium tin oxide, indium zinc oxide, or an In—Ga—Zn oxide may be used. The separation layer is preferably formed using a high-melting point metal material such as tungsten, titanium, or molybdenum, in which case the degree of freedom of the process for forming the layers to be separated can be increased. (225) The separation layer can be formed by, for example, a sputtering method, a plasma CVD method, a coating method (including a spin coating method, a droplet discharge method, a dispensing method, and the like), or a printing method. The thickness of the separation layer is, for example, greater than or equal to 10 nm and less than or equal to 20 nm, preferably greater than or equal to 20 nm and less than or equal to 100 nm.
- (226) In the case where the separation layer has a single-layer structure, a tungsten layer, a molybdenum layer, or a layer containing a mixture of tungsten and molybdenum is preferably formed. Alternatively, a layer containing an oxide or an oxynitride of tungsten, a layer containing an oxide or an oxynitride of molybdenum, or a layer containing an oxide or an oxynitride of a mixture of tungsten and molybdenum may be formed. Note that a mixture of tungsten and molybdenum is an alloy of tungsten and molybdenum, for example.
- (227) In the case where the separation layer is formed to have a layered structure including a layer containing tungsten and a layer containing an oxide of tungsten, the layer containing an oxide of tungsten may be formed as follows: the layer containing tungsten is formed first and an insulating film formed of an oxide is formed thereover, so that the layer containing an oxide of tungsten is formed at the interface between the tungsten layer and the insulating film. Alternatively, the layer containing an oxide of tungsten may be formed by performing thermal oxidation treatment, oxygen plasma treatment, nitrous oxide (N.sub.2O) plasma treatment, treatment with a highly oxidizing solution such as ozone water, or the like on the surface of the layer containing tungsten. Plasma treatment or heat treatment may be performed in an atmosphere of oxygen, nitrogen, or nitrous oxide alone, or a mixed gas of any of these gasses and another gas. Surface condition of the

separation layer is changed by the plasma treatment or heat treatment, whereby adhesion between the separation layer and the insulating film formed later can be controlled.

- (228) Note that the separation layer is not necessarily provided in the case where separation at the interface between the formation substrate and the layer to be separated is possible. For example, a glass substrate is used as the formation substrate, and an organic resin such as polyimide, polyester, polyolefin, polyamide, polycarbonate, or acrylic is formed in contact with the glass substrate. Next, adhesion between the formation substrate and the organic resin is increased by laser light irradiation or heat treatment. Then, an insulating film, a transistor, and the like are formed over the organic resin. After that, separation at the interface between the formation substrate and the organic resin can be performed by performing laser light irradiation with higher energy density than that of the above laser light irradiation or performing heat treatment at a higher temperature than that for the above heat treatment. Moreover, the interface between the formation substrate and the organic resin may be soaked in a liquid to perform separation.
- (229) Since the insulating film, the transistor, and the like are formed over the organic resin having low heat resistance in the above method, it is impossible to expose the substrate to high temperatures in the manufacturing process. Note that a transistor using an oxide semiconductor is not necessarily processed at high temperature and thus can be favorably formed over the organic resin.
- (230) The organic resin may be used for a substrate of the device. Alternatively, the organic resin may be removed and another substrate may be bonded to an exposed surface of the layer to be separated with the use of an adhesive. In addition, the organic resin may be bonded to another substrate (a supporting film) using an adhesive.
- (231) Alternatively, separation at the interface between a metal layer and the organic resin may be performed in the following manner: a metal layer is provided between the formation substrate and the organic resin and current is made to flow in the metal layer so that the metal layer is heated. (232) The insulating layer (the first layer) in contact with the separation layer preferably has a single-layer structure or a multilayer structure including any of a silicon nitride film, a silicon oxynitride film, a silicon oxide film, a silicon nitride oxide film, and the like. Note that a material for the insulating layer is not limited thereto, and an optimum material can be selected depending on a material used for the separation layer.
- (233) The insulating layer can be formed by a sputtering method, a plasma CVD method, a coating method, a printing method, or the like. For example, the insulating layer is formed at higher than or equal to 250° C. and lower than or equal to 400° C. by a plasma CVD method, whereby the insulating layer can be a dense film with high moisture resistance. The thickness of the insulating layer ranges preferably from 10 nm to 3000 nm, more preferably from 200 nm to 1500 nm. (234) Next, the formation substrate **301** and the formation substrate **321** are attached to each other with a bonding layer **307** such that surfaces on which the layers to be separated are formed face
- (235) Note that the formation substrate **301** and the formation substrate **321** are preferably attached to each other in a reduced-pressure atmosphere.
- (236) Note that although FIG. **13**C illustrates the case where the separation layer **303** and the separation layer **323** are different in size, separation layers having the same size as illustrated in FIG. **13**D may be used.

each other, and the bonding layer **307** is cured (see FIG. **13**C).

- (237) The bonding layer **307** is provided to overlap with the separation layer **303**, the layer **305**, the layer **325**, and the separation layer **323**. Then, the end portion of the bonding layer **307** is preferably positioned inward from at least the end portion of either the separation layer **303** or the separation layer **323** (the separation layer which is desirably separated first). Accordingly, strong adhesion between the formation substrate **301** and the formation substrate **321** can be suppressed; thus, a decrease in yield of a subsequent separating process can be suppressed.
- (238) As the bonding layer 307, various curable adhesives such as a reactive curable adhesive, a

thermosetting adhesive, an anaerobic adhesive, and a photocurable adhesive such as an ultraviolet curable adhesive can be used. Examples of these adhesives include an epoxy resin, an acrylic resin, a silicone resin, a phenol resin, a polyimide resin, an imide resin, a PVC resin, a PVB resin, and an EVA resin. A material with low moisture permeability, such as an epoxy resin, is particularly preferred. For the adhesive, a material having fluidity low enough to dispose the material only in a desired region is preferably used. For example, an adhesive sheet, a bonding sheet, or a sheet-like or film-like adhesive can be used, and an optical clear adhesive (OCA) film can be preferably used. (239) The adhesive may have adhesion before attachment or exhibit adhesion after attachment by heating or light irradiation.

- (240) Furthermore, the resin may include a drying agent. For example, it is possible to use a substance that adsorbs moisture by chemical adsorption, such as oxide of an alkaline earth metal (e.g., calcium oxide or barium oxide), or a substance that adsorbs moisture by physical adsorption, such as zeolite or silica gel. The drying agent is preferably included, in which case it can suppress deterioration of the functional element due to entry of moisture in the air and can improve the reliability of the device.
- (241) Next, a separation trigger is formed by laser irradiation (FIGS. 14A and 14B).
- (242) Either the formation substrate **301** or the formation substrate **321** can be separated first. In the case where the separation layers differ in size, a substrate over which a larger separation layer is formed may be separated first or a substrate over which a smaller separation layer is formed may be separated first. In the case where an element such as a semiconductor element or a light-emitting element is formed only over one of the substrates, the substrate on the side where the element is formed may be separated first or the other substrate may be separated first. Here, the formation substrate **301** is separated first.
- (243) A region where the bonding layer **307** in a cured state, the layer **305**, and the separation layer **303** overlap with one another is irradiated with laser light (see the arrow P1 in FIG. **14**A). (244) Part of the first layer is removed; thus, the separation trigger can be formed (see a region surrounded by a dashed line in FIG. **14**B). At this time, not only the first layer but also the separation layer **303**, the bonding layer **307**, or another layer included in the layer **305** may be partly removed.
- (245) It is preferred that laser light irradiation be performed from the side of the substrate provided with the separation layer that is desirably separated. In the case where a region where the separation layer **303** and the separation layer **323** overlap with each other is irradiated with laser light, the formation substrate **301** and the separation layer **303** can be selectively separated from each other by cracking only the layer **305** of the layers **305** and **325** (see a region surrounded by the dotted line in FIG. **14**B). Here, an example in which layers of the layer **305** are partly removed is shown.
- (246) Then, the layer **305** and the formation substrate **301** are separated from each other from the formed separation trigger (FIGS. **14**C and **14**D). Consequently, the layer **305** can be transferred from the formation substrate **301** to the formation substrate **321**.
- (247) For example, the layer **305** and the formation substrate **301** may be separated from each other from the separation trigger with mechanical force (e.g., a separation process with a human hand or a gripper, or a separation process by rotation of a roller).
- (248) The formation substrate **301** and the layer **305** may be separated from each other by making a liquid such as water permeate the interface between the separation layer **303** and the layer **305**. A portion between the separation layer **303** and the layer **305** absorbs a liquid through a capillarity action, facilitating separation. Furthermore, an adverse effect on the functional element included in the layer **305** due to static electricity caused at separation (e.g., a phenomenon in which a semiconductor element is damaged by static electricity) can be suppressed.
- (249) Next, the exposed layer **305** is attached to a substrate **331** with a bonding layer **333**, and the bonding layer **333** is cured (FIG. **15**A).

- (250) Note that the layer **305** and the substrate **331** are preferably attached to each other in a reduced-pressure atmosphere.
- (251) Subsequently, a separation trigger is formed by laser light irradiation (FIGS. **15**B and **15**C).
- (252) A region where the bonding layer **333** in a cured state, the layer **325**, and the separation layer **323** overlap with each other is irradiated with laser light (see the arrow P2 in FIG. **15**B). Part of the first layer is removed; thus, the separation trigger can be formed (see a region surrounded by a dashed line in FIG. **15**C. Here, an example in which layers of the layer **325** are partly removed is shown). At this time, not only the first layer but also the separation layer **323**, the bonding layer **333**, or another layer included in the layer **325** may be partly removed. Laser light is preferably delivered toward the formation substrate **321** provided with the separation layer **323**.
- (253) Then, the layer **325** and the formation substrate **321** are separated from each other from the separation trigger (see FIG. **15**D). Accordingly, the layer **305** and the layer **325** can be transferred to the substrate **331**.
- (254) After that, another substrate may be bonded to the layer **325**.
- (255) The exposed layer **325** is attached to a substrate **341** with a bonding layer **343**, and the bonding layer **343** is cured (FIG. **16**A). FIG. **16**A shows an example in which an opening has been already formed in the substrate **341**.
- (256) In this manner, the separated layers can be sandwiched between the pair of flexible substrates.
- (257) After that, unnecessary end portions of the substrate **331**, the substrate **341**, and the like may be cut and removed as shown in FIG. **16**B. Part of the end portions of the layers **305** and **325** may be cut at the same time.
- (258) By the above method, a flexible device can be fabricated. The separated layers having the structure described in the above embodiment can be used to fabricate a flexible display device. (259) In the above method for manufacturing the display device of one embodiment of the present invention, a pair of formation substrates each provided with a separation layer and a layer to be separated are attached to each other, and then, a separation trigger is formed by laser light irradiation to make separation of the layer to be separated from the separation layer easier. As a result, the yield of the separation process can be improved.
- (260) In addition, separation is performed after the formation substrates each provided with the separated layer are attached to each other in advance, and then a substrate that is included in a device desired to be fabricated can be attached to the separated layer. As described above, formation substrates having low flexibility can be attached to each other when the layers to be separated are attached to each other; thus, alignment accuracy at the time of attachment can be improved compared with the case where flexible substrates are attached to each other.
- (261) As shown in FIG. **17**A, the end portion of a separation region **351** of the layer **305** is preferably positioned inward from the end portion of the separation layer **303**. This can improve the yield of the separation process. When there is a plurality of regions **351**, the separation layer **303** may be provided for each region **351** as shown in FIG. **17**B, or the plurality of regions **351** may be provided over one separation layer **303** as shown in FIG. **17**C.
- (262) The above is the description of a manufacturing method of a flexible display device.
- (263) At least part of this embodiment can be implemented in combination with any of the other embodiments described in this specification as appropriate.

Embodiment 4

- (264) In this embodiment, examples of electronic devices that can include a display device of one embodiment of the present invention will be described.
- (265) Electronic devices and lighting devices can be manufactured using the display device of one embodiment of the present invention. Electronic devices and lighting devices with high display quality can be manufactured using the display device of one embodiment of the present invention. Electronic devices and lighting devices with favorable viewing angle characteristics can be

- manufactured using the display device of one embodiment of the present invention. Electronic devices and lighting devices with low power consumption can be manufactured using the display device of one embodiment of the present invention. In addition, highly reliable electronic devices and highly reliable lighting devices can be manufactured using the display device of one embodiment of the present invention.
- (266) Examples of electronic devices include a television set, desktop and laptop personal computers, monitors of a computer and the like, a digital camera, a digital video camera, a digital photo frame, a mobile phone, a portable game machine, a portable information terminal, an audio reproducing device, and a large game machine such as a pachinko machine. The electronic device or the lighting device of one embodiment of the present invention can be incorporated along a curved inside/outside wall surface of a house or a building or a curved interior/exterior surface of a car.
- (267) The electronic device of one embodiment of the present invention may include a secondary battery. Preferably, the secondary battery is capable of being charged by contactless power transmission.
- (268) Examples of the secondary battery include a lithium ion secondary battery such as a lithium polymer battery (lithium ion polymer battery) using a gel electrolyte, a nickel-hydride battery, a nickel-cadmium battery, an organic radical battery, a lead-acid battery, an air secondary battery, a nickel-zinc battery, and a silver-zinc battery.
- (269) The electronic device of one embodiment of the present invention may include an antenna. When a signal is received by the antenna, a video, information, or the like can be displayed on a display portion. When the electronic device includes an antenna and a secondary battery, the antenna may be used for contactless power transmission.
- (270) The electronic device of one embodiment of the present invention may include a sensor (a sensor having a function of measuring force, displacement, position, speed, acceleration, angular velocity, rotational frequency, distance, light, liquid, magnetism, temperature, chemical substance, sound, time, hardness, electric field, current, voltage, electric power, radiation, flow rate, humidity, gradient, oscillation, odor, or infrared rays).
- (271) The electronic device of one embodiment of the present invention can have a variety of functions such as a function of displaying a variety of information (e.g., a still image, a moving image, and a text image) on the display portion, a touch panel function, a function of displaying a calendar, date, time, and the like, a function of executing a variety of kinds of software (programs), a wireless communication function, and a function of reading out a program or data stored in a recording medium.
- (272) Furthermore, the electronic device including a plurality of display portions can have a function of displaying image information mainly on one display portion while displaying text information mainly on another display portion, a function of displaying a three-dimensional image by displaying images where parallax is considered on a plurality of display portions, or the like. Furthermore, the electronic device including an image receiving portion can have a function of photographing a still image or a moving image, a function of automatically or manually correcting a photographed image, a function of storing a photographed image in a recording medium (an external recording medium or a recording medium incorporated in the electronic device), a function of displaying a photographed image on a display portion, or the like. Note that the functions of the electronic devices of embodiments of the present invention are not limited thereto, and the electronic devices can have a variety of functions.
- (273) FIGS. **18**A to **18**E illustrate examples of electronic devices each including a display portion **7000** with a curved surface. Since the display surface of the display portion **7000** is curved, images can be displayed on the curved display surface. The display portion **7000** may have flexibility. (274) The display portion **7000** is formed using the display device or the like of one embodiment of the present invention. One embodiment of the present invention makes it possible to provide a

- highly reliable electronic device with low power consumption and a curved display portion. (275) FIGS. **18**A and **18**B illustrate examples of mobile phones. A mobile phone **7100** illustrated in FIG. **18**A and a mobile phone **7110** illustrated in FIG. **18**B each include a housing **7101**, the display portion **7000**, operation buttons **7103**, an external connection port **7104**, a speaker **7105**, a microphone **7106**, and the like. The mobile phone **7110** illustrated in FIG. **18**B also includes a camera **7107**.
- (276) Each mobile phone includes a touch sensor in the display portion **7000**. Operations such as making a call and inputting text can be performed by touch on the display portion **7000** with a finger, a stylus, or the like.
- (277) With the operation buttons **7103**, the power can be turned on or off. In addition, types of images displayed on the display portion **7000** can be changed; for example, switching from a mail creation screen to a main menu screen can be performed.
- (278) When a detection device such as a gyroscope or an acceleration sensor is provided inside the mobile phone, the direction of display on the screen of the display portion **7000** can be automatically changed by determining the orientation of the mobile phone (whether the mobile phone is placed horizontally or vertically). Furthermore, the direction of display on the screen can be changed by touch on the display portion **7000**, operation with the operation button **7103**, sound input using the microphone **7106**, or the like.
- (279) FIGS. **18**C and **18**D illustrate examples of portable information terminals. A portable information terminal **7200** illustrated in FIG. **18**C and a portable information terminal **7210** illustrated in FIG. **18**D each include a housing **7201** and the display portion **7000**. Each of the portable information terminals may also include an operation button, an external connection port, a speaker, a microphone, an antenna, a camera, a battery, or the like. The display portion **7000** is provided with a touch sensor. The operation of the portable information terminal can be performed by touching the display portion **7000** with a finger, a stylus, or the like.
- (280) Each of the portable information terminals illustrated in this embodiment functions as, for example, one or more of a telephone set, a notebook, and an information browsing system. Specifically, the portable information terminals can each be used as a smartphone. Each of the portable information terminals illustrated in this embodiment is capable of executing, for example, a variety of applications such as mobile phone calls, e-mailing, reading and editing text, music reproduction, Internet communication, and a computer game.
- (281) The portable information terminals **7200** and **7210** can display text, image information, and the like on their plurality of surfaces. For example, as illustrated in FIGS. **18**C and **18**D, three operation buttons **7202** can be displayed on one surface, and information **7203** indicated by a rectangle can be displayed on another surface. FIG. **18**C illustrates an example in which information is displayed on the top of the portable information terminal. FIG. **18**D illustrates an example in which information is displayed on the side of the portable information terminal. Information may be displayed on three or more surfaces of the portable information terminal. (282) Examples of the information include notification from a social networking service (SNS), display indicating reception of an e-mail or an incoming call, the title of an e-mail or the like, the sender of an e-mail or the like, the date, the time, remaining battery level, and the reception sensitivity of an antenna. Alternatively, the operation button, an icon, or the like may be displayed instead of the information.
- (283) For example, a user of the portable information terminal **7200** can see the display (here, the information **7203**) on the portable information terminal **7200** put in a breast pocket of his/her clothes.
- (284) Specifically, a caller's phone number, name, or the like of an incoming call is displayed in a position that can be seen from above the portable information terminal **7200**. Thus, the user can see the display without taking out the portable information terminal **7200** from the pocket and decide whether to answer the call.

- (285) FIG. **18**E illustrates an example of a television set. In a television set **7300**, the display portion **7000** is incorporated into a housing **7301**. Here, the housing **7301** is supported by a stand **7303**.
- (286) The television set **7300** illustrated in FIG. **18**E can be operated with an operation switch of the housing **7301** or a separate remote controller **7311**. The display portion **7000** may include a touch sensor, and can be operated by touch on the display portion **7000** with a finger or the like. The remote controller **7311** may be provided with a display portion for displaying data output from the remote controller **7311**. With operation keys or a touch panel of the remote controller **7311**, channels and volume can be controlled and a video displayed on the display portion **7000** can be controlled.
- (287) Note that the television set **7300** is provided with a receiver, a modem, and the like. A general television broadcast can be received with the receiver. When the television set is connected to a communication network with or without wires via the modem, one-way (from a transmitter to a receiver) or two-way (between a transmitter and a receiver or between receivers) data communication can be performed.
- (288) FIG. **18**F illustrates an example of a lighting device having a curved light-emitting portion. (289) The light-emitting portion included in the lighting device illustrated in FIG. **18**F can be manufactured using the display device or the like of one embodiment of the present invention. According to one embodiment of the present invention, a highly reliable lighting device with low power consumption and a curved light-emitting portion can be provided.
- (290) A light-emitting portion **7411** included in a lighting device **7400** illustrated in FIG. **18**F has two convex-curved light-emitting portions symmetrically placed. Thus, light radiates from the lighting device **7400** in all directions.
- (291) The light-emitting portion **7411** included in the lighting device **7400** may have flexibility. The light-emitting portion **7411** may be fixed on a plastic member, a movable frame, or the like so that a light-emitting surface of the light-emitting portion **7411** can be bent freely depending on the intended use.
- (292) The lighting device **7400** includes a stage **7401** provided with an operation switch **7403** and the light-emitting portion **7411** supported by the stage **7401**.
- (293) Note that although the lighting device in which the light-emitting portion is supported by the stage is described as an example here, a housing provided with a light-emitting portion can be fixed on a ceiling or suspended from a ceiling. Since the light-emitting surface can be curved, the light-emitting surface is curved to have a concave shape, whereby a particular region can be brightly illuminated, or the light-emitting surface is curved to have a convex shape, whereby a whole room can be brightly illuminated.
- (294) FIGS. **19**A to **19**I illustrate examples of portable information terminals each including a flexible and bendable display portion **7001**.
- (295) The display portion **7001** is manufactured using the display device or the like of one embodiment of the present invention. For example, a display device or the like that can be bent with a radius of curvature of greater than or equal to 0.01 mm and less than or equal to 150 mm can be used. The display portion **7001** may include a touch sensor so that the portable information terminal can be operated by touch on the display portion **7001** with a finger or the like. One embodiment of the present invention makes it possible to provide a highly reliable electronic device including a display portion having flexibility.
- (296) FIGS. **19**A and **19**B are perspective views illustrating an example of the portable information terminal. A portable information terminal **7500** includes a housing **7501**, the display portion **7001**, a display portion tab **7502**, operation buttons **7503**, and the like. The portable information terminal **7500** includes the rolled flexible display portion **7001** in the housing **7501**. The display portion **7001** can be pulled out with the display portion tab **7502**.
- (297) The portable information terminal **7500** can receive a video signal with a control portion

- incorporated therein and can display the received video on the display portion **7001**. The portable information terminal **7500** incorporates a battery. A terminal portion for connecting a connector may be included in the housing **7501** so that a video signal and power can be directly supplied from the outside with a wiring.
- (298) By pressing the operation buttons **7503**, power ON/OFF, changing of displayed videos, and the like can be performed. Although FIGS. **19**A and **19**B show an example in which the operation buttons **7503** are positioned on a side surface of the portable information terminal **7500**, one embodiment of the present invention is not limited thereto. The operation buttons **7503** may be placed on a display surface (a front surface) or a rear surface of the portable information terminal **7500**.
- (299) FIG. **19**B illustrates the portable information terminal **7500** in a state where the display portion **7001** is pulled out. A video can be displayed on the display portion **7001** in this state. In addition, the portable information terminal **7500** may perform different types of display in the state where part of the display portion **7001** is rolled as shown in FIG. **19**A and in the state where the display portion **7001** is pulled out as shown in FIG. **19**B. For example, in the state shown in FIG. **19**A, the rolled portion of the display portion **7001** is put in a non-display state, reducing the power consumption of the portable information terminal **7500**.
- (300) Note that a reinforcement frame may be provided for a side portion of the display portion **7001** so that the display portion **7001** has a flat display surface when pulled out.
- (301) Note that in addition to this structure, a speaker may be provided for the housing so that sound is output with an audio signal received together with a video signal.
- (302) FIGS. **19**C to **19**E illustrate an example of a foldable portable information terminal. FIG. **19**C illustrates a portable information terminal **7600** that is unfolded. FIG. **19**D illustrates the portable information terminal **7600** that is being unfolded or folded. FIG. **19**E illustrates the portable information terminal **7600** that is folded. The portable information terminal **7600** is highly portable when folded, and is highly browsable when unfolded because of a seamless large display area. (303) The display portion **7001** is supported by three housings **7601** joined together by hinges **7602**. By folding the portable information terminal **7600** at a connection portion between two housings **7601** with the hinges **7602**, the portable information terminal **7600** can be reversibly changed in shape from an unfolded state to a folded state.
- (304) FIGS. **19**F and **19**G illustrate an example of a foldable portable information terminal. FIG. **19**F illustrates a portable information terminal **7650** that is folded so that the display portion **7001** is on the inside. FIG. **19**G illustrates the portable information terminal **7650** that is folded so that the display portion **7001** is on the outside. The portable information terminal **7650** includes the display portion **7001** and a non-display portion **7651**. When the portable information terminal **7650** is not used, the portable information terminal **7650** is folded so that the display portion **7001** is on the inside, whereby the display portion **7001** can be prevented from being contaminated and damaged.
- (305) FIG. **19**H illustrates an example of a flexible portable information terminal. A portable information terminal **7700** includes a housing **7701** and the display portion **7001**. The portable information terminal **7700** may further include buttons **7703***a* and **7703***b* serving as input portions, speakers **7704***a* and **7704***b* serving as sound output portions, an external connection port **7705**, a microphone **7706**, or the like. A flexible battery **7709** can be included in the portable information terminal **7700**. The battery **7709** may be arranged to overlap with the display portion **7001**, for example.
- (306) The housing **7701**, the display portion **7001**, and the battery **7709** have flexibility. Thus, it is easy to curve the portable information terminal **7700** into a desired shape and to twist the portable information terminal **7700**. For example, the portable information terminal **7700** can be folded so that the display portion **7001** is on the inside or on the outside. The portable information terminal **7700** can be used in a rolled state. Since the housing **7701** and the display portion **7001** can be

- transformed freely in this manner, the portable information terminal **7700** is less likely to be broken even when the portable information terminal **7700** falls down or external stress is applied to the portable information terminal **7700**.
- (307) The portable information terminal **7700** is lightweight and therefore can be used conveniently in various situations. For example, the portable information terminal **7700** can be used in the state where the upper portion of the housing **7701** is suspended by a clip or the like, or in the state where the housing **7701** is fixed to a wall by magnets or the like.
- (308) FIG. **19**I illustrates an example of a wrist-watch-type portable information terminal. The portable information terminal **7800** includes a band **7801**, the display portion **7001**, an input/output terminal **7802**, operation buttons **7803**, and the like. The band **7801** has a function of a housing. A flexible battery **7805** can be included in the portable information terminal **7800**. The battery **7805** may be provided to overlap with the display portion **7001**, the band **7801**, or the like, for example. (309) The band **7801**, the display portion **7001**, and the battery **7805** have flexibility. Thus, the portable information terminal **7800** can be easily curved to have a desired shape.
- (310) With the operation buttons **7803**, a variety of functions such as time setting, ON/OFF of the power, ON/OFF of wireless communication, setting and cancellation of a silent mode, and setting and cancellation of a power saving mode can be performed. For example, the functions of the operation buttons **7803** can be set freely by the operating system incorporated in the portable information terminal **7800**.
- (311) By touch on an icon **7804** displayed on the display portion **7001** with a finger or the like, an application can be started.
- (312) The portable information terminal **7800** can employ near field communication conformable to a communication standard. For example, mutual communication between the portable information terminal and a headset capable of wireless communication can be performed, and thus hands-free calling is possible.
- (313) The portable information terminal **7800** may include the input/output terminal **7802**. In the case where the input/output terminal **7802** is included in the portable information terminal **7800**, data can be directly transmitted to and received from another information terminal via a connector. Charging through the input/output terminal **7802** is also possible. Note that charging of the portable information terminal described as an example in this embodiment can be performed by contactless power transmission without using the input/output terminal.
- (314) FIG. **20**A is an external view of an automobile **7900**. FIG. **20**B illustrates a driver's seat of the automobile **7900**. The automobile **7900** includes a car body **7901**, wheels **7902**, a windshield **7903**, lights **7904**, fog lamps **7905**, and the like.
- (315) The display device of one embodiment of the present invention can be used in a display portion of the automobile **7900**. For example, the display device of one embodiment of the present invention can be used in display portions **7910** to **7917** illustrated in FIG. **20**B.
- (316) The display portion **7910** and the display portion **7911** are provided in the automobile windshield. The display device of one embodiment of the present invention can be a see-through device, through which the opposite side can be seen, by using a light-transmitting conductive material for its electrodes. Such a see-through display device does not hinder driver's vision during the driving of the automobile **7900**. Therefore, the display device of one embodiment of the present invention can be provided in the windshield of the automobile **7900**. Note that in the case where a transistor or the like is provided in the display device, a transistor having light-transmitting properties, such as an organic transistor using an organic semiconductor material or a transistor using an oxide semiconductor, is preferably used.
- (317) A display portion **7912** is provided on a pillar portion. A display portion **7913** is provided on a dashboard. For example, the display portion **7912** can compensate for the view hindered by the pillar portion by showing an image taken by an imaging portion provided on the car body. Similarly, the display portion **7913** can compensate for the view hindered by the dashboard and a

- display portion **7914** can compensate for the view hindered by the door. That is, showing a video taken by an imaging portion provided on the outside of the automobile leads to elimination of blind areas and enhancement of safety. In addition, showing a video so as to compensate for the area which a driver cannot see makes it possible for the driver to confirm safety easily and comfortably. (318) The display portion **7917** is provided in a steering wheel. The display portion **7915**, the display portion **7916**, or the display portion **7917** can display a variety of kinds of information such as navigation information, a speedometer, a tachometer, a mileage, a fuel meter, a gearshift indicator, and air-condition setting. The content, layout, or the like of the display on the display portions can be customized freely by a user as appropriate. The information listed above can also be displayed on the display portions **7910** to **7914**.
- (319) The display portions **7910** to **7917** can also be used as lighting devices.
- (320) A display portion included in the display device of one embodiment of the present invention may have a flat surface. In that case, the display device of one embodiment of the present invention does not necessarily have a curved surface and flexibility.
- (321) FIGS. **20**C and **20**D illustrate examples of digital signages. The digital signages each include a housing **8000**, a display portion **8001**, a speaker **8003**, and the like. Also, the digital signages can each include an LED lamp, operation keys (including a power switch or an operation switch), a connection terminal, a variety of sensors, a microphone, and the like.
- (322) FIG. **20**D illustrates a digital signage mounted on a cylindrical pillar.
- (323) A larger display portion **8001** can provide more information at a time. In addition, a larger display portion **8001** attracts more attention, so that the effectiveness of the advertisement is expected to be increased, for example.
- (324) It is preferable to use a touch panel in the display portion **8001** because a device with such a structure does not just display a still or moving image, but can be operated by users intuitively. Alternatively, in the case where the device is used to provide information such as route information or traffic information, usability can be enhanced by intuitive operation. FIG. **20**E illustrates a portable game console including a housing **8101**, a housing **8102**, a display portion **8103**, a display portion **8104**, a microphone **8105**, a speaker **8106**, an operation key **8107**, a stylus **8108**, and the like.
- (325) The portable game console illustrated in FIG. **20**E includes two display portions **8103** and **8104**. Note that the number of display portions of the electronic device of one embodiment of the present invention is not limited to two and can be one or three or more as long as at least one display portion includes the display device of one embodiment of the present invention.
- (326) FIG. **20**F illustrates a laptop personal computer which includes a housing **8111**, a display portion **8112**, a keyboard **8113**, a pointing device **8114**, and the like.
- (327) The display device of one embodiment of the present invention can be used for the display portion **8112**.
- (328) FIG. **21**A is an external view of a camera **8400** to which a finder **8500** is attached. The camera **8400** includes a housing **8401**, a display portion **8402**, an operation button **8403**, a shutter button **8404**, and the like. Furthermore, an attachable lens **8406** is attached to the camera **8400**. (329) Although the lens **8406** of the camera **8400** here is detachable from the housing **8401** for
- (329) Although the lens **8406** of the camera **8400** here is detachable from the housing **8401** for replacement, the lens **8406** may be built into a housing.
- (330) When the shutter button **8404** is pressed, the camera **8400** can take images. In addition, the display portion **8402** has a function of a touch panel, and images can be taken when the display portion **8402** is touched.
- (331) The housing **8401** of the camera **8400** has a mount including an electrode, and the finder **8500**, a stroboscope, and the like can be connected.
- (332) The finder **8500** includes a housing **8501**, a display portion **8502**, a button **8503**, and the like.
- (333) The housing **8501** includes a mount for engagement with the mount of the camera **8400** so that the finder **8500** can be connected to the camera **8400**. The mount includes an electrode, and a

- moving image or the like received from the camera **8400** through the electrode can be displayed on the display portion **8502**.
- (334) The button **8503** serves as a power button. The display portion **8502** can be turned on and off using the button **8503**.
- (335) A display device of one embodiment of the present invention can be used for the display portion **8402** of the camera **8400** and the display portion **8502** of the finder **8500**.
- (336) Although the camera **8400** and the finder **8500** are separate and detachable electronic devices in FIG. **21**A, a finder including the display device of one embodiment of the present invention may be built into the housing **8401** of the camera **8400**.
- (337) FIG. **21**B is an external view of a head-mounted display **8200**.
- (338) The head-mounted display **8200** includes a mounting portion **8201**, a lens **8202**, a main body **8203**, a display portion **8204**, a cable **8205**, and the like. In addition, a battery **8206** is built into the mounting portion **8201**.
- (339) Power is supplied from the battery **8206** to the main body **8203** through the cable **8205**. The main body **8203** includes a wireless receiver or the like to receive video data such as image data and display it on the display portion **8204**. The movement of the user's eyeball or eyelid is captured by a camera in the main body **8203** and then the coordinates of the eyepoint are calculated using the captured data to utilize the user's eye as an input portion.
- (340) A plurality of electrodes may be provided in in a portion of the mounting portion **8201** a user touches. The main body **8203** may have a function of sensing a current flowing through the electrodes with the movement of the user's eyeball to determine the location of the eyepoint. The main body **8203** may have a function of sensing a current flowing through the electrodes to monitor the user's pulse. The mounting portion **8201** may include sensors such as a temperature sensor, a pressure sensor, or an acceleration sensor so that the user's biological information can be displayed on the display portion **8204**. The main body **8203** may sense the movement of the user's head or the like to move an image displayed on the display portion **8204** in synchronization with the movement of the user's head, or the like.
- (341) The display device of one embodiment of the present invention can be used for the display portion **8204**.
- (342) FIGS. 21C and 21D are external views of a head-mounted display 8300.
- (343) The head-mounted display **8300** includes a housing **8301**, two display portions **8302**, an operation button **8303**, and a fixing band **8304**.
- (344) The head-mounted display **8300** has the functions of the above-described head-mounted display **8200** and includes two display portions.
- (345) Since the head-mounted display **8300** includes the two display portions **8302**, the user's eyes can see their respective display portions. Thus, a high-definition image can be displayed even when a three-dimensional display using parallax, or the like, is performed. In addition, the display portion **8302** is curved around an arc with the user's eye as an approximate center. Owing to this, the distance between the user's eye and the display surface of the display portion is uniform; thus, the user can see a more natural image. Even when the luminance or chromaticity of light emitted from the display portion varies depending on the user' viewing angle, the influence of the variation can be substantially ignorable and thus a more realistic image can be displayed because the user's eye is positioned in the normal direction of the display surface of the display portion.
- (346) The operation button **8303** serves as a power button or the like. A button other than the operation button **8303** may be included.
- (347) As illustrated in FIG. **21**E, lenses **8305** may be provided between the display portion **8302** and the user's eyes. The user can see magnified images on the display portion **8302** through the lenses **8305**, leading to higher sense of presence. In that case, as illustrated in FIG. **21**E, a dial **8306** for changing the position of the lenses and adjusting visibility may be included.
- (348) The display device of one embodiment of the present invention can be used for the display

- portion **8302**. Since the display device of one embodiment of the present invention has extremely high definition, even when an image is magnified using the lenses **8305** as illustrated in FIG. **21**E, the pixels are not perceived by the user, and thus a more realistic image can be displayed.
- (349) FIGS. **22**A to **22**C are examples in which the head-mounted display includes one display portion **8302**. Such a structure can reduce the number of components.
- (350) The display portion **8302** can display an image for the right eye and an image for the left eye side by side on a right region and a left region, respectively. Thus, a three-dimensional moving image using binocular disparity can be displayed.
- (351) One image which can be seen by both eyes may be displayed on all over the display portion **8302**. A panorama moving image can thus be displayed from end to end of the field of view; thus, the sense of reality is increased.
- (352) As shown in FIG. **22**C, the lenses **8305** may be provided. Two images may be displayed side by side on the display portion **8302**. Alternatively, one image may be displayed on the display portion **8302** and seen by both eyes through the lenses **8305**.
- (353) At least part of this embodiment can be implemented in combination with any of the other embodiments described in this specification as appropriate.

EXAMPLE

- (354) The time required to charge and discharge wirings of a display device of one embodiment of the present invention, and the like, were calculated. FIG. **26**A is a block diagram of the display device used for the calculation. FIG. **26**B is a circuit diagram of a fabricated pixel corresponding to the top view.
- (355) The block diagram of the display device in FIG. **26**A illustrates a so-called 8K panel, which has a dimension of 65 inches and includes 7680×4320 pixels (PIX) composed of subpixels for red, green, blue, and white (RGBW) arranged in stripes. Scan line driver circuits (Gate Driver) provided on opposite sides are fabricated by gate on array (GOA) and output scan signals to the pixels (PIX). A signal line driver circuit (Source Driver) is externally provided.
- (356) FIG. **26**B is a circuit diagram of the pixel (PIX) illustrated in FIG. **26**A. The configuration of the circuit diagram in FIG. **26**B corresponds to the configuration in FIG. **7**A in which the position of the capacitor C**2** is changed.
- (357) In the configuration in FIG. **26**B, a first gate electrode and a second gate electrode are not connected to each other in the transistor M**4** as in FIG. **7**A. With this configuration, the gate capacitance between a scan line GL and the transistor M**4** is formed only between the scan line GL and the first gate electrode in contrast to a configuration where gate electrodes are connected to each other.
- (358) FIG. **27** is a top view of the pixel (PIX) corresponding to FIG. **26**B. The pixel illustrated in FIG. **27** includes four subpixels for RGBW. Note that components corresponding to those in the circuit diagram are denoted by the same reference symbols. The time required to charge and discharge wirings such as a scan line and a signal line was estimated using the configurations illustrated in FIGS. **26**A and **26**B and FIG. **27**. Various calculations to estimate the time required for charge and discharge were conducted using the software SmartSpice produced by SILVACO, Inc. Note that the pixel size is 188 μ m×188 μ m, the transistor M**4** has a channel length L of 4 μ m and a channel width W of 4 μ m, and the transistor M**5** has a channel length L of 6 μ m and a channel width W of 6 μ m.
- (359) Table 1 shows the calculation results. In Table 1, "Gate fall time" refers to time required for a scan signal to fall, "Source line charge time (>95%)" refers to time required to charge the signal line to 95%, "Total" refers to the total of Gate fall time and Source line charge time, and "One horizontal period" refers to one horizontal scanning period.
- (360) TABLE-US-00001 TABLE 1 Gate Source line charge One horizontal fall time time(>95%) Total period 0.90 μs 0.97 μs 1.87 μs 1.92 μs
- (361) As shown in Table 1, time required to charge and discharge the scan line and the signal line

falls within one horizontal scanning period. This implies that the display device of one embodiment of the present invention, in which the gate capacitance of the transistor connected to the scan line is small, is suitable for an 8K panel.

EXPLANATION OF REFERENCE

(362) GL: scan line, SL: signal line, V0: wiring, ANODE: current supply line, M1: transistor, M2: transistor, M3: transistor, C1: capacitor, EL: light-emitting element, CATHODE: common wiring, 100: transistor, 102: substrate, 104: insulating layer, 106: conductive layer, 108: oxide semiconductor layer, 110: insulating layer, 112: oxide semiconductor layer, 116: insulating layer, **108***i*: channel region, **108***s*: source region, **108***d*: drain region, **141***a*: opening, **141***b*: opening, **120***a*: conductive layer, **120***b*: conductive layer, **151**: conductive layer, **152**: conductive layer, **153**: insulating layer, 161: oxide semiconductor layer, 162: oxide semiconductor layer, 163: oxide semiconductor layer, 164: insulating layer, 171: oxide semiconductor layer, 172: oxide semiconductor layer, 173: oxide semiconductor layer, 174: insulating layer, 181: conductive layer, 182: conductive layer, 183: conductive layer, 184: conductive layer, 185: conductive layer, 186: insulating layer, 187: insulating layer, 190: opening, 191: conductive layer, 192: conductive layer, 193: insulating layer, 198: light-emitting layer, 199: partition layer, 10: display device, 11: pixel portion, 12: scan line driver circuit, 13: signal line driver circuit, 15: terminal portion, 16a: wiring, **16***b*: wiring, **22**: region, **24**: region, M**4**: transistor, M**5**: transistor, M**6**: transistor, M**7**: transistor, **M8**: transistor, **M9**): transistor, **M10**: transistor, **M1**: transistor, **C2**: capacitor, **C3**: capacitor, **C4**: capacitor, C5: capacitor, GL1: scan line, GL2: scan line, GL3: scan line, GL4: scan line, V1: wiring, V2: wiring, 201: substrate, 202: substrate, 211: insulating layer, 212: insulating layer, 213: insulating layer, 214: insulating layer, 215: spacer, 216: insulating layer, 217: insulating layer, 218: insulating layer, 220): bonding layer, 221: insulating layer, 222: EL layer, 223: electrode, 224: optical adjustment laver, 225: pixel electrode, 230a: structure, 230b: structure, 231: light-blocking layer, 232: coloring layer, 242: FOP, 243: connection layer, 250: space, 251: transistor, 252: transistor, **253**: capacitor, **254**: light-emitting element, **255**: transistor, **260**: sealing material, **261**: bonding layer, 262: bonding layer, 271: semiconductor layer, 272: conductive layer, 273: conductive layer, 274: conductive layer, 275: conductive layer, 276: insulating layer, 291: conductive layer, 292: conductive layer, 293: conductive layer, 294: insulating layer, 295: bonding layer, 296: substrate, 297: FOP, 298: connection layer, 299: terminal portion, 301: formation substrate, **303**: separation layer, **305**: layer to be separated, **307**: bonding layer, **321**: formation substrate, **323**: separation layer, **325**: layer to be separated, **331**: substrate, **333**: bonding layer, **341**: substrate, **343**: bonding layer, **351**: region, **7000**: display portion, **7001**: display portion, **7100**: mobile phone, **7101**: housing, **7103**: operation button, **7104**: external connection port, **7105**: speaker, 7106: microphone, 7107: camera, 7110: mobile phone, 7200: portable information terminal, **7201**: housing, **7202**: operation button, **7203**: information, **7210**: portable information terminal, 7300: television set, 7301: housing, 7303: stand, 7311: remote controller, 7400: lighting device, 7401: stage, 7403: operation switch, 7411: light-emitting portion, 7500: portable information terminal, 7501: housing, 7502: display portion tab, 7503: operation button, 7600: portable information terminal, **7601**: housing, **7602**: hinge, **7650**: portable information terminal, **7651**: non-display portion, **7700**: portable information terminal, **7701**: housing, **7703***a*: button, 7703*b*: button, 7704*a*: speaker, 7704*b*: speaker, 7705: external connection port, 7706: microphone, 7709: battery, 7800: portable information terminal, 7801: band, 7802: input-output terminal, 7803: operation button, **7804**: icon, **7805**: battery, **7900**: automobile, **7901**: car body, **7902**: wheel, **7903**: windshield, 7904: light, 7905: fog lamp, 7910: display portion, 7911: display portion, 7912: display portion, 7913: display portion, 7914: display portion, 7915: display portion, 7916: display portion, **7917**: display portion, **8000**: housing, **8001**: display portion, **8003**: speaker, **8101**: housing, **8102**: housing, 8103: display portion, 8104: display portion, 8105: microphone, 8106: speaker, 8107: operation key, 8108: stylus, 8111: housing, 8112: display portion, 8113: keyboard, 8114: pointing device, 8200: head-mounted display, 8201: mounting portion, 8202: lens, 8203: main body, 8204:

display portion, **8205**: cable, **8206**: battery, **8300**: head-mounted display, **8301**: housing, **8302**: display portion, **8303**: operation button, **8304**: fixing band, **8305**: lens, **8306**: dial, **8400**: camera, **8401**: housing, **8402**: display portion, **8403**: operation button, **8404**: shutter button, **8406**: lens, **8500**: finder, **8501**: housing, **8502**: display portion, **8503**: button.

(363) This application is based on Japanese Patent Application serial no. 2015-256583 filed with Japan Patent Office on Dec. 28, 2015 and Japanese Patent Application serial no. 2016-218998 filed with Japan Patent Office on Nov. 9, 2016, the entire contents of which are hereby incorporated by reference.

Claims

- 1. A light-emitting device comprising a pixel portion, the pixel portion comprising: a first transistor, a second transistor, and a third transistor, and a light-emitting element, wherein one of a source and a drain of the second transistor is electrically connected to a signal line which is configured to supply a signal corresponding to image data, wherein the second transistor is configured to control supply of the signal corresponding to the image data to a pixel, wherein one of a source and a drain of the third transistor is electrically connected to a wiring, wherein the other of the source and the drain of the third transistor is electrically connected to a pixel electrode of the light-emitting element, wherein the light-emitting device further comprises: a first conductive layer functioning as a first gate electrode of the first transistor; a second conductive layer over the first conductive layer, the second conductive layer functioning as a second gate electrode of the first transistor; a third conductive layer over the first conductive layer, the third conductive layer functioning as a gate electrode of the third transistor; a fourth conductive layer over the second conductive layer and the third conductive layer, the fourth conductive layer functioning as the wiring; a fifth conductive layer over the second conductive layer and the third conductive layer, the fifth conductive layer functioning as one of the source and the drain of the second transistor; a sixth conductive layer over the second conductive layer and the third conductive layer, the sixth conductive layer functioning as the other of the source and the drain of the third transistor; a seventh conductive layer over the second conductive layer and the third conductive layer; an eighth conductive layer functioning as a current supply line; and a ninth conductive layer functioning as the signal line, wherein the fifth conductive layer is electrically connected to the ninth conductive layer, wherein the sixth conductive layer is electrically connected to the pixel electrode, wherein the seventh conductive layer is electrically connected to the eighth conductive layer, wherein, in a top view, the eighth conductive layer comprises a region overlapping with the fourth conductive layer, wherein, when the eighth conductive layer and the light-emitting element are in a conduction state through the seventh conductive layer, a channel region of the first transistor, and the sixth conductive layer, a current based on the image data flows in the light-emitting element, and wherein the eighth conductive layer and the ninth conductive layer are positioned over the fourth conductive layer, the fifth conductive layer, the sixth conductive layer, and the seventh conductive layer.
- 2. The light-emitting device according to claim 1, wherein the second conductive layer and the third conductive layer are in the same layer.
- 3. The light-emitting device according to claim 1, wherein the fourth conductive layer, the fifth conductive layer, the sixth conductive layer, and the seventh conductive layer are in the same layer.
- 4. The light-emitting device according to claim 1, wherein the eighth conductive layer and the ninth conductive layer are in the same layer.
- 5. The light-emitting device according to claim 1, wherein each of the eighth conductive layer and the ninth conductive layer comprises a three-layer structure comprising a first film, a second film over the first film, and a third film over the second film, wherein each of the first film and the third film comprises a titanium film or a titanium nitride film, and wherein the second film comprises an aluminum film or a copper film.

- 6. The light-emitting device according to claim 1, wherein the channel region of the first transistor comprises a polycrystalline semiconductor.
- 7. The light-emitting device according to claim 1, further comprising an insulating layer over the sixth conductive layer, wherein the sixth conductive layer is electrically connected to the pixel electrode through an opening included in the insulating layer.
- 8. The light-emitting device according to claim 1, wherein a gate electrode of the second transistor is electrically connected to a first scan line, and wherein a gate electrode of the third transistor is electrically connected to a second scan line which is different from the first scan line.
- 9. A light-emitting device comprising a pixel portion, the pixel portion comprising: a first transistor, a second transistor, and a third transistor, and a light-emitting element, wherein one of a source and a drain of the second transistor is electrically connected to a signal line which is configured to supply a signal corresponding to image data, wherein the second transistor is configured to control supply of the signal corresponding to the image data to a pixel, wherein one of a source and a drain of the third transistor is electrically connected to a wiring, wherein the other of the source and the drain of the third transistor is electrically connected to a pixel electrode of the light-emitting element, and wherein the light-emitting device further comprises: a first conductive layer functioning as a first gate electrode of the first transistor; a second conductive layer over the first conductive layer, the second conductive layer functioning as a second gate electrode of the first transistor; a third conductive layer over the first conductive layer, the third conductive layer functioning as a gate electrode of the third transistor; a fourth conductive layer over the second conductive layer and the third conductive layer, the fourth conductive layer functioning as the wiring; a fifth conductive layer over the second conductive layer and the third conductive layer, the fifth conductive layer functioning as one of the source and the drain of the second transistor; a sixth conductive layer over the second conductive layer and the third conductive layer, the sixth conductive layer functioning as the other of the source and the drain of the third transistor; a seventh conductive layer over the second conductive layer and the third conductive layer; an eighth conductive layer functioning as a current supply line; and a ninth conductive layer functioning as the signal line.
- 10. The light-emitting device according to claim 9, wherein a channel region of the first transistor comprises a polycrystalline semiconductor.
- 11. The light-emitting device according to claim 9, wherein a gate electrode of the second transistor is electrically connected to a first scan line, and wherein a gate electrode of the third transistor is electrically connected to a second scan line which is different from the first scan line.